



中国科学院大学  
University of Science and Technology of China

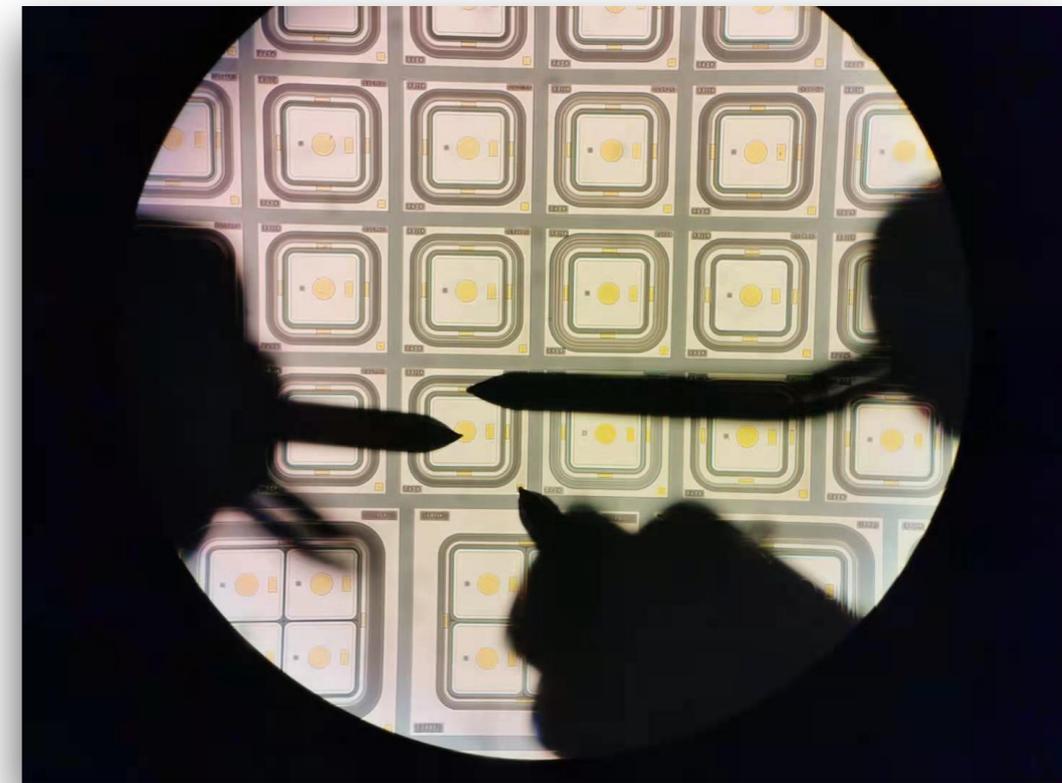
# Performance of the USTC first batch LGADs

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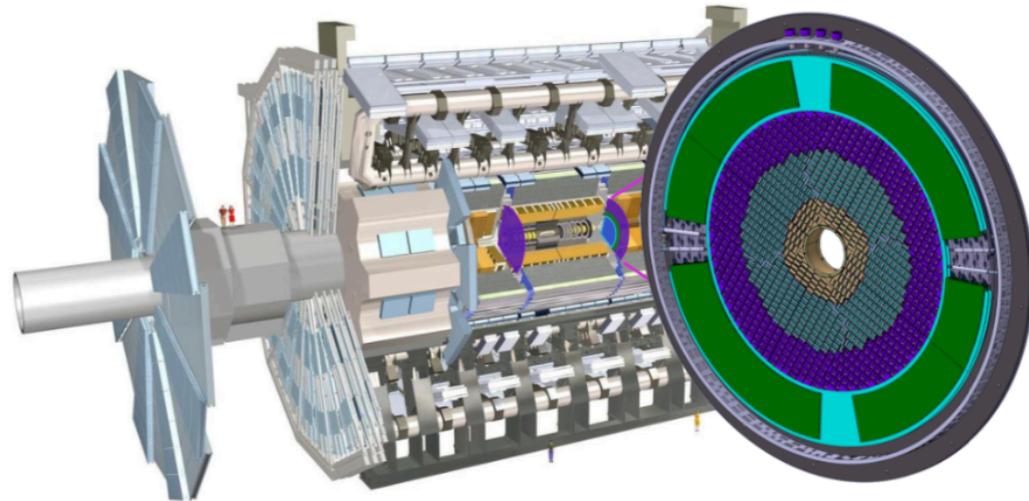
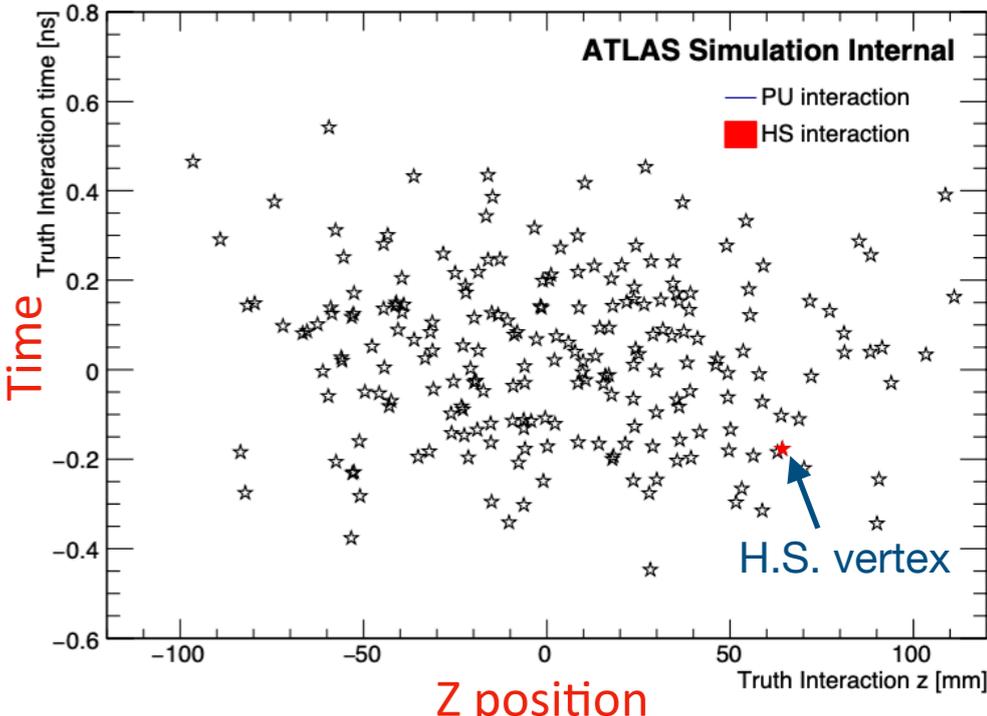
*16th "Trento" Workshop on Advanced Silicon Radiation Detectors  
February 18th, 2021*



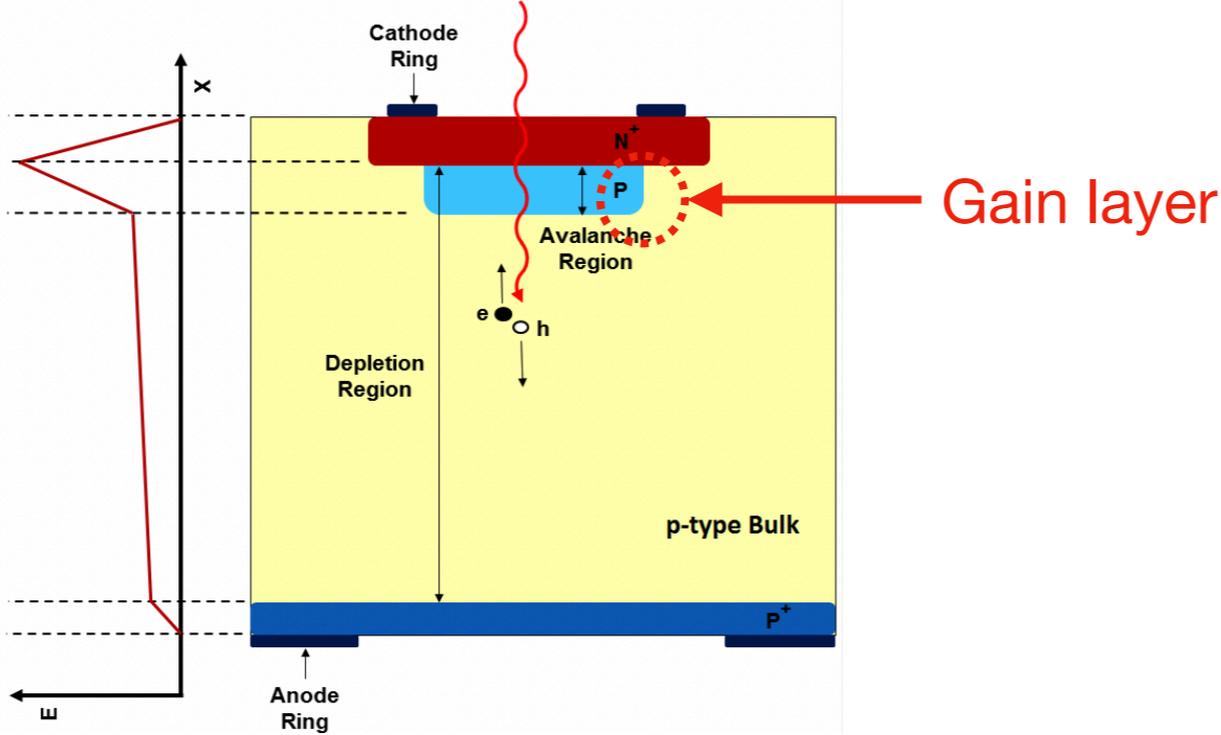
# The High-Granularity Timing Detector(HGTD) for the ATLAS Phase-II Upgrade

## Motivation and Technique

- In the HL-LHC, Pile-up density would get so high that **track to vertex association** would be very hard, especially in the forward region
- Having a timing detector in forward region would allow us **make the matching in “4-D” space**.
- A novel technology: LGAD (**Low-Gain Avalanche Detector**), which achieves promising  $S/N$  and  $\sigma_t$  by inducing an internal gain layer.



•  $\sigma_t \sim 30$  ps per track



larger gain

↓

faster rising time and larger S/N

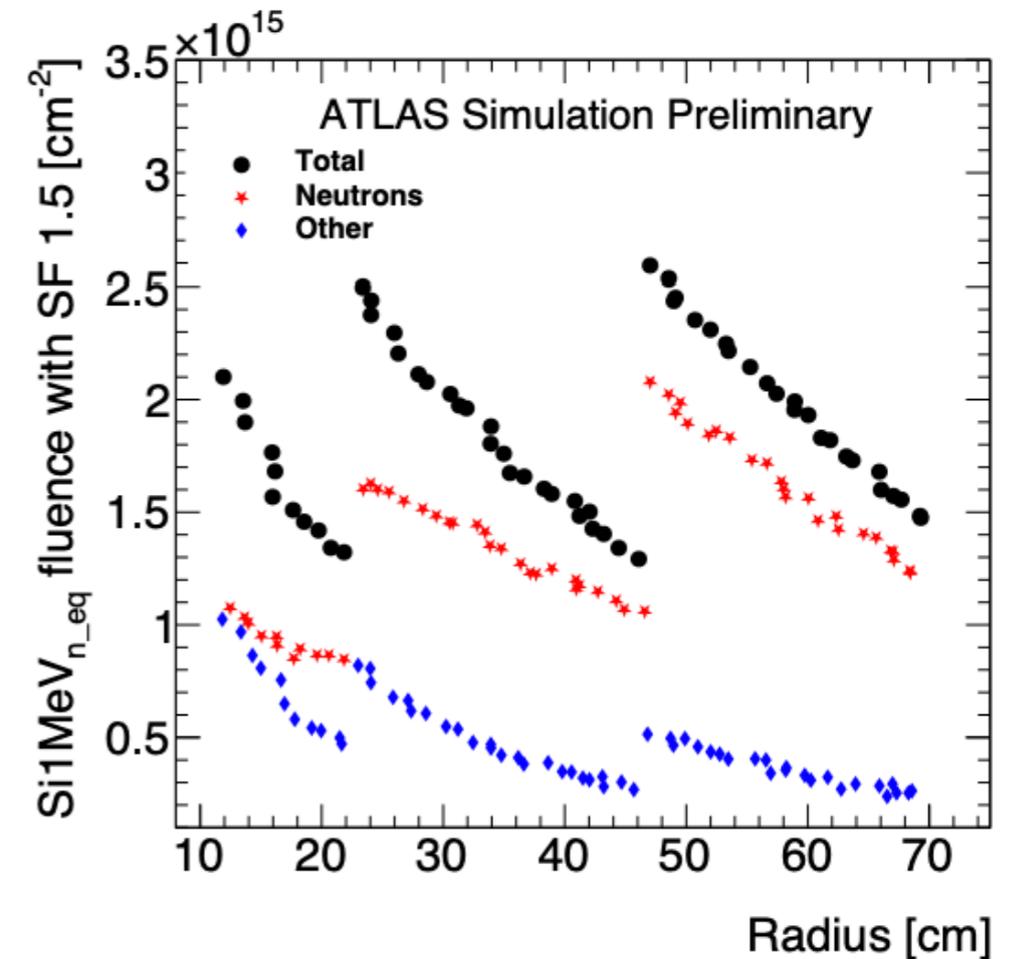
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better time resolution

# LGAD Sensor R&D

## Challenges on LGAD Design

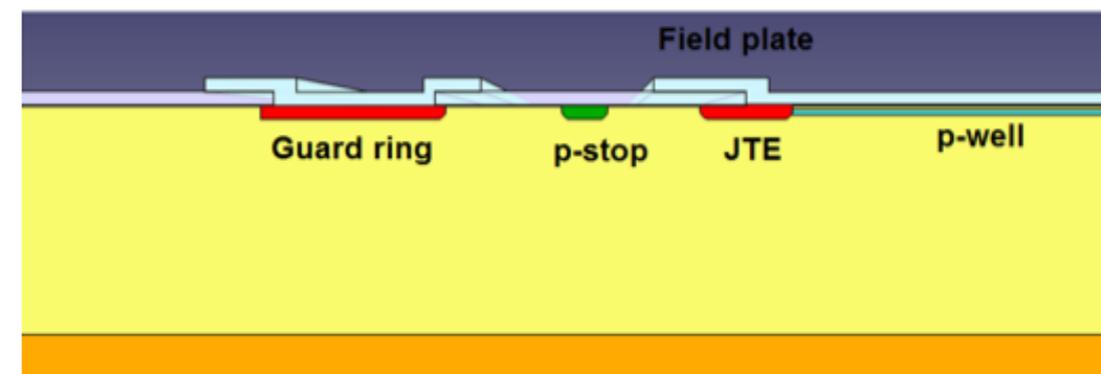
- **Radiation Hardness:**
  - Acceptor removal
    - **Solutions:**
      - **Narrow** and **deep** implantation of boron
      - **Carbon** diffusion
- **Premature breakdown:**
  - Optimization of the **peripheral region** to prevent premature breakdown (to ~800V)
  - Implementation of the structures commonly used in **power semiconductor device**:  
Guard ring, JTE, Field plate



HGTD's requirement on the NIEL fluence

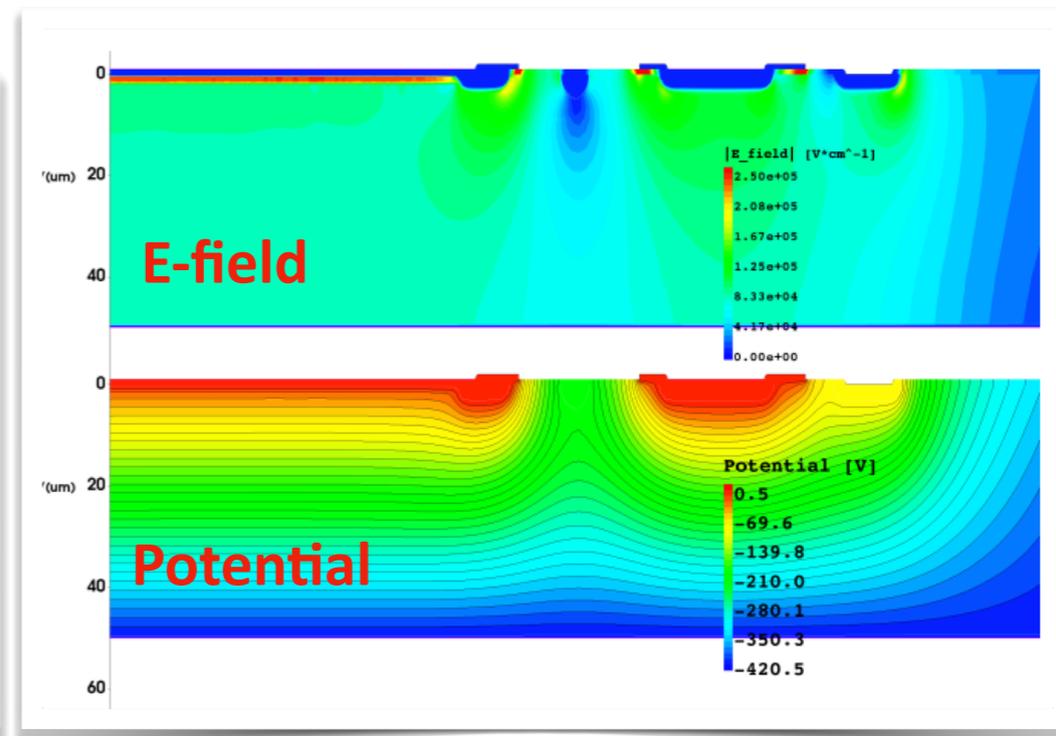
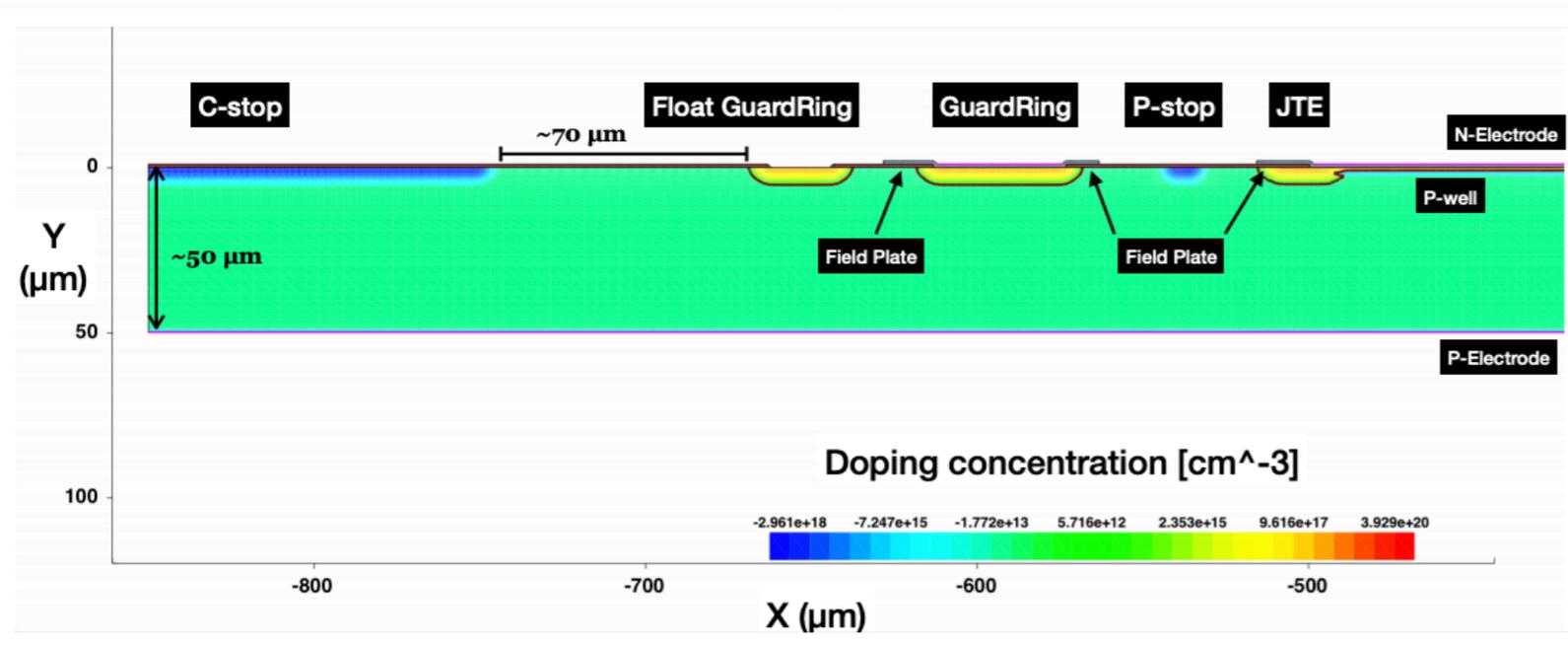
$$\rho_A(\phi) = g_{eff}\phi + \rho_A(0)e^{-c\phi}$$

Acceptor density with NIEL fluence



Structures to avoid premature breakdown

# USTC-LGAD Design with TCAD

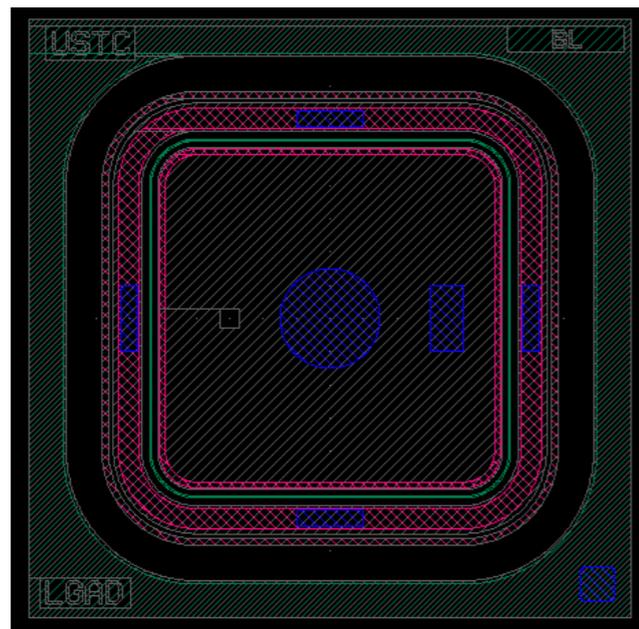


- TCAD structure based on process simulation
- The geometry and process are thoroughly optimized
- Major radiation damage model included

## ➔ Recommendation:

- High resist. substrate:  $> 1\text{k}\Omega\cdot\text{cm}$
- High energy boron implantation: at least  $\sim 1\text{MeV}$
- Carbon diffusion on one wafer

Simulation ➔ **Layout Mask**  
 ➔ **Fab. Process** ➔ **Functional USTC LGADs**



Designed mask

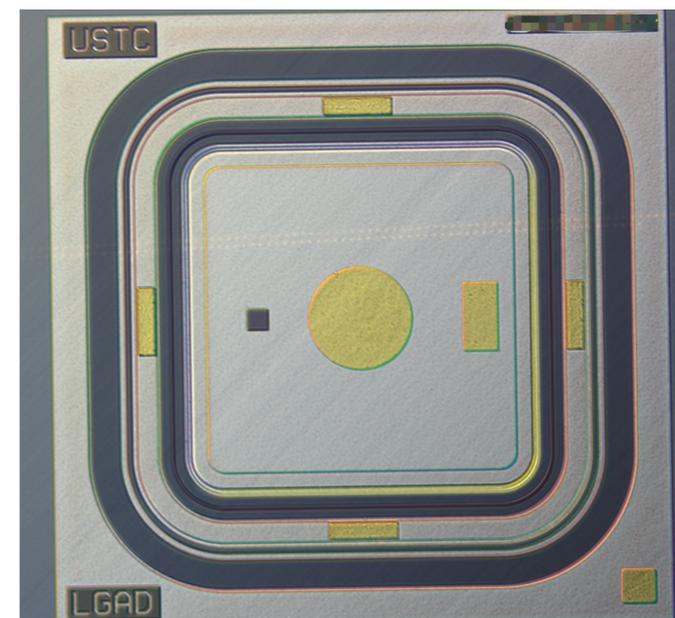
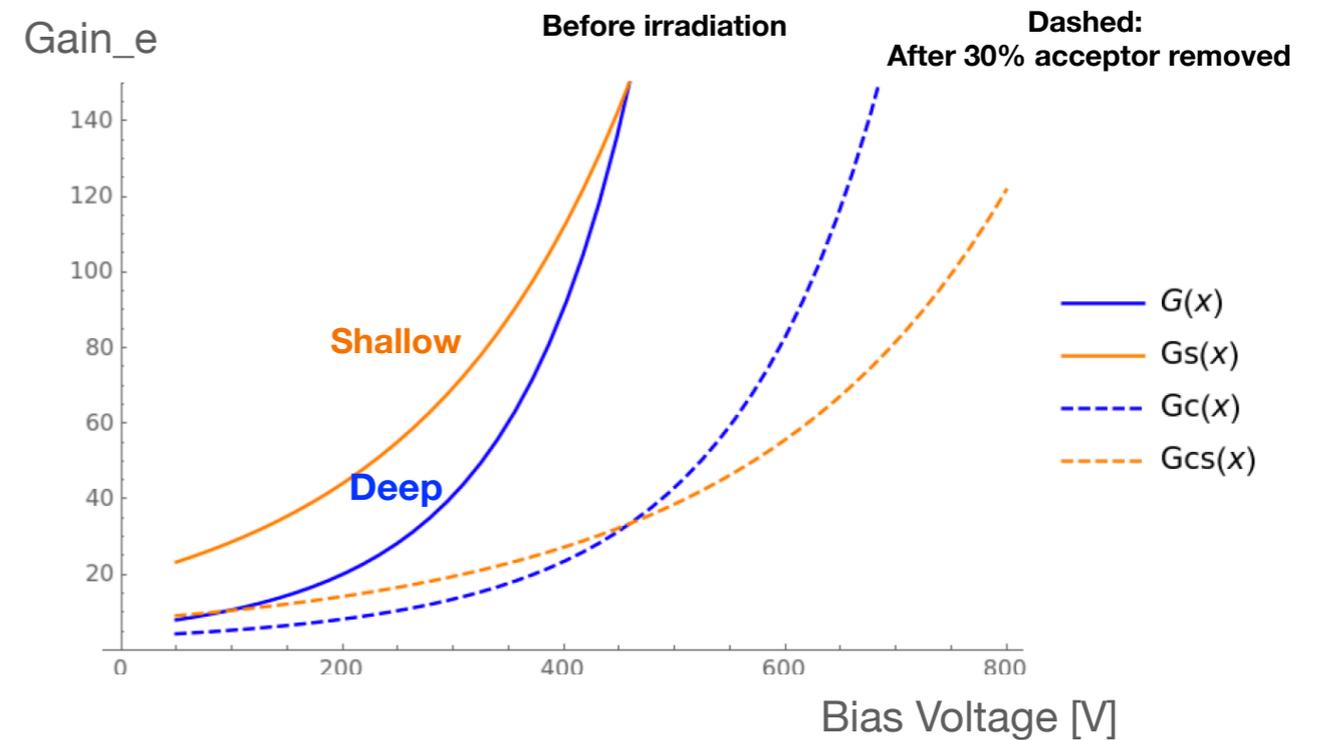
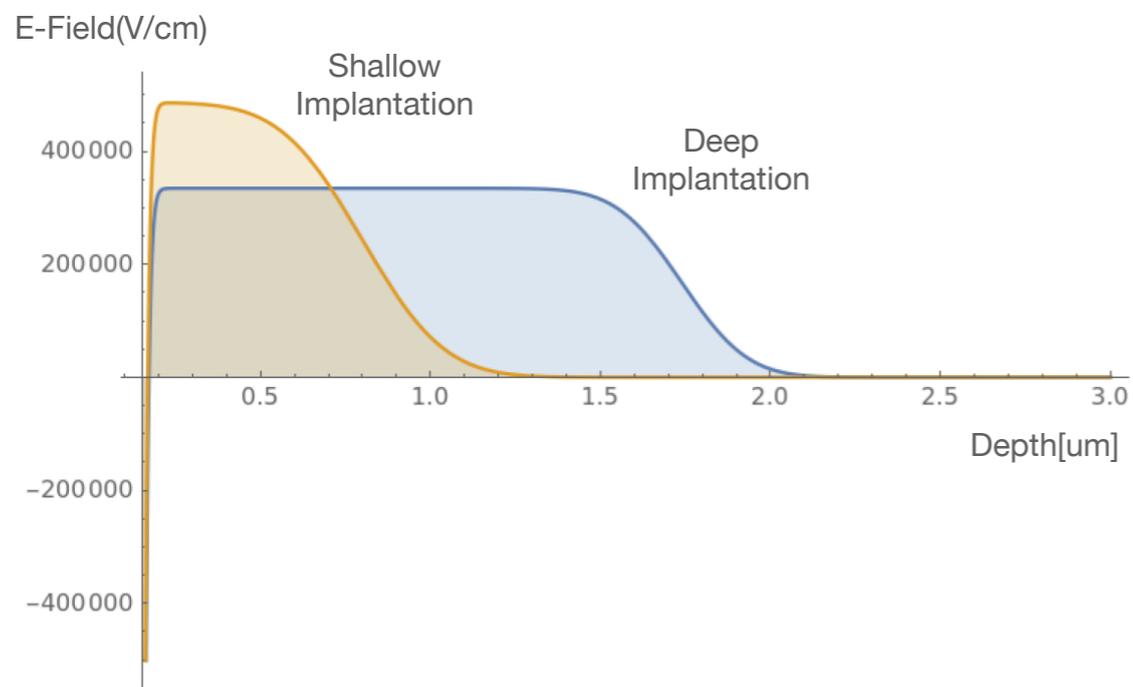
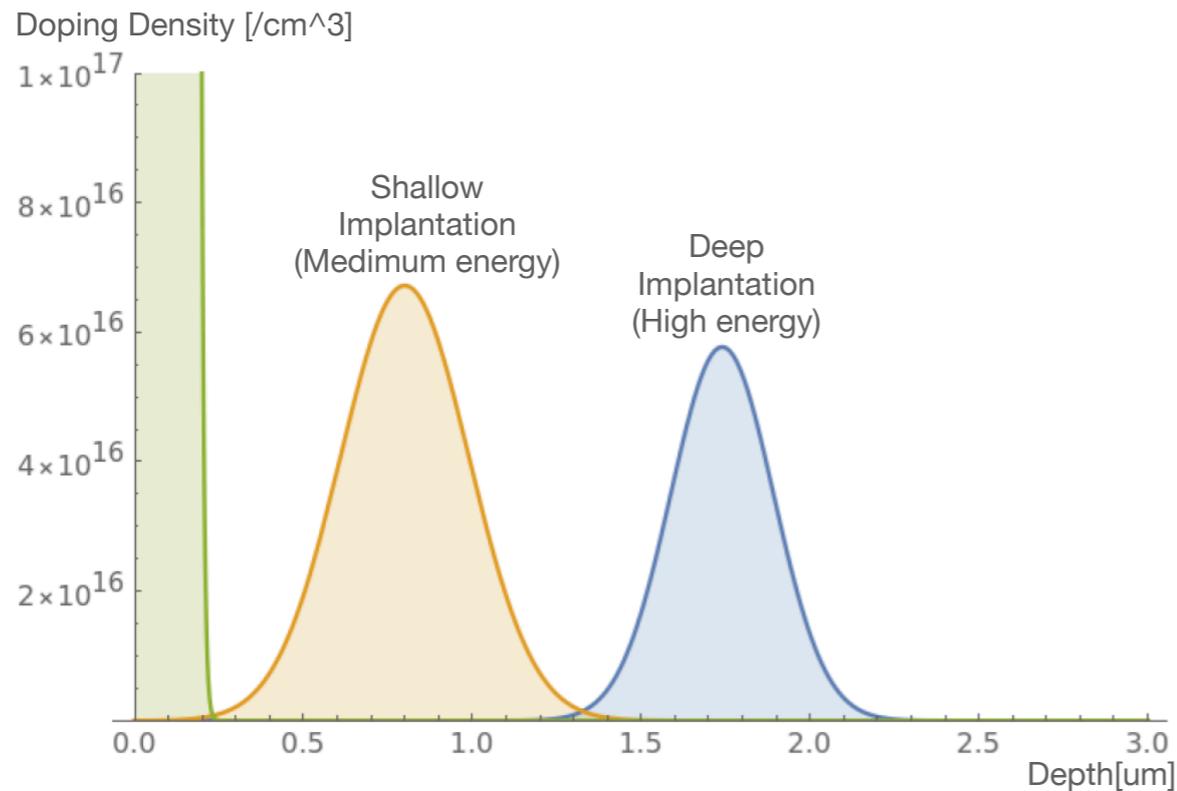


Photo of the device produced

# Deep vs Shallow Gain Layer

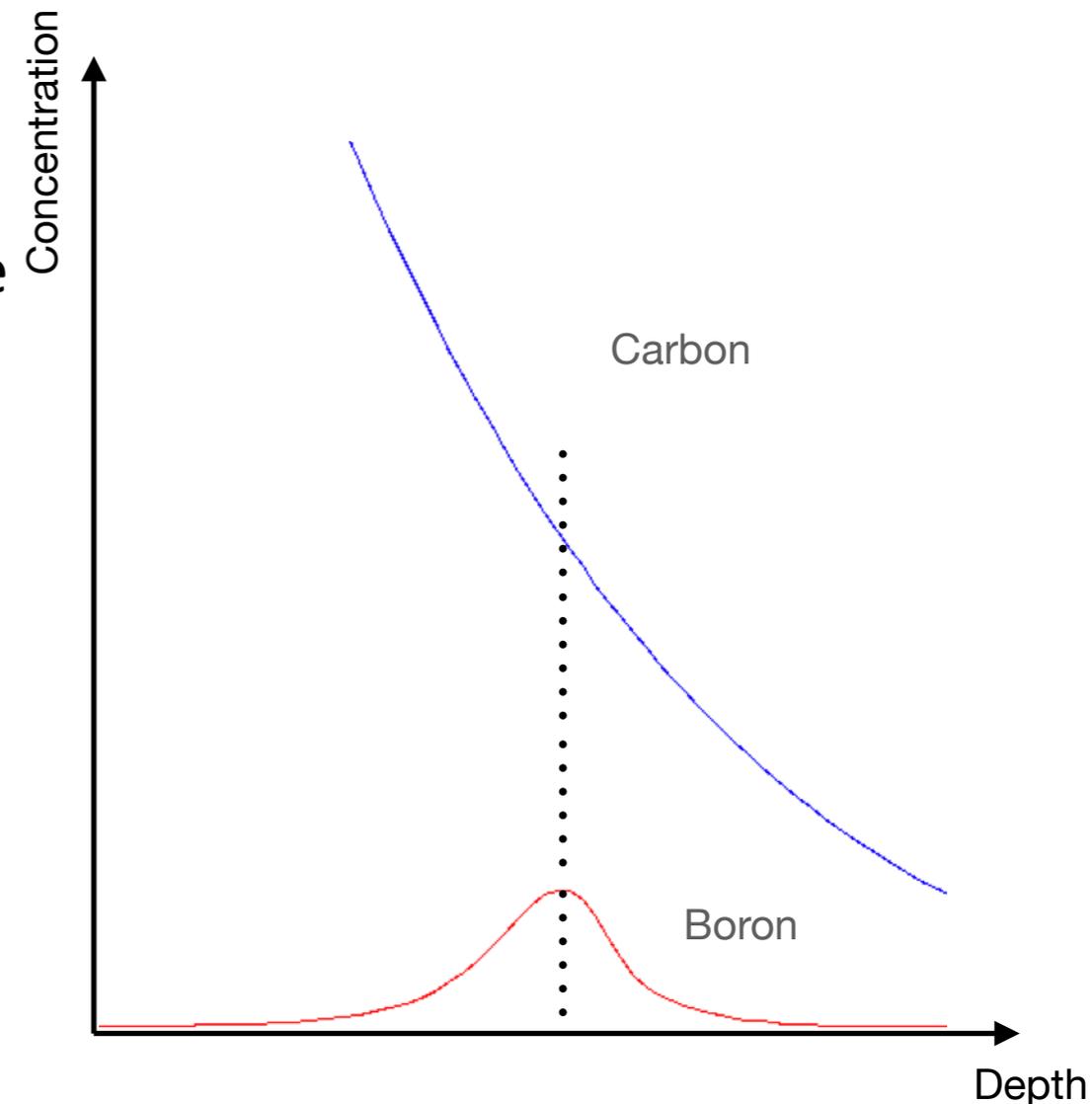
Calculation based on the Massey Model



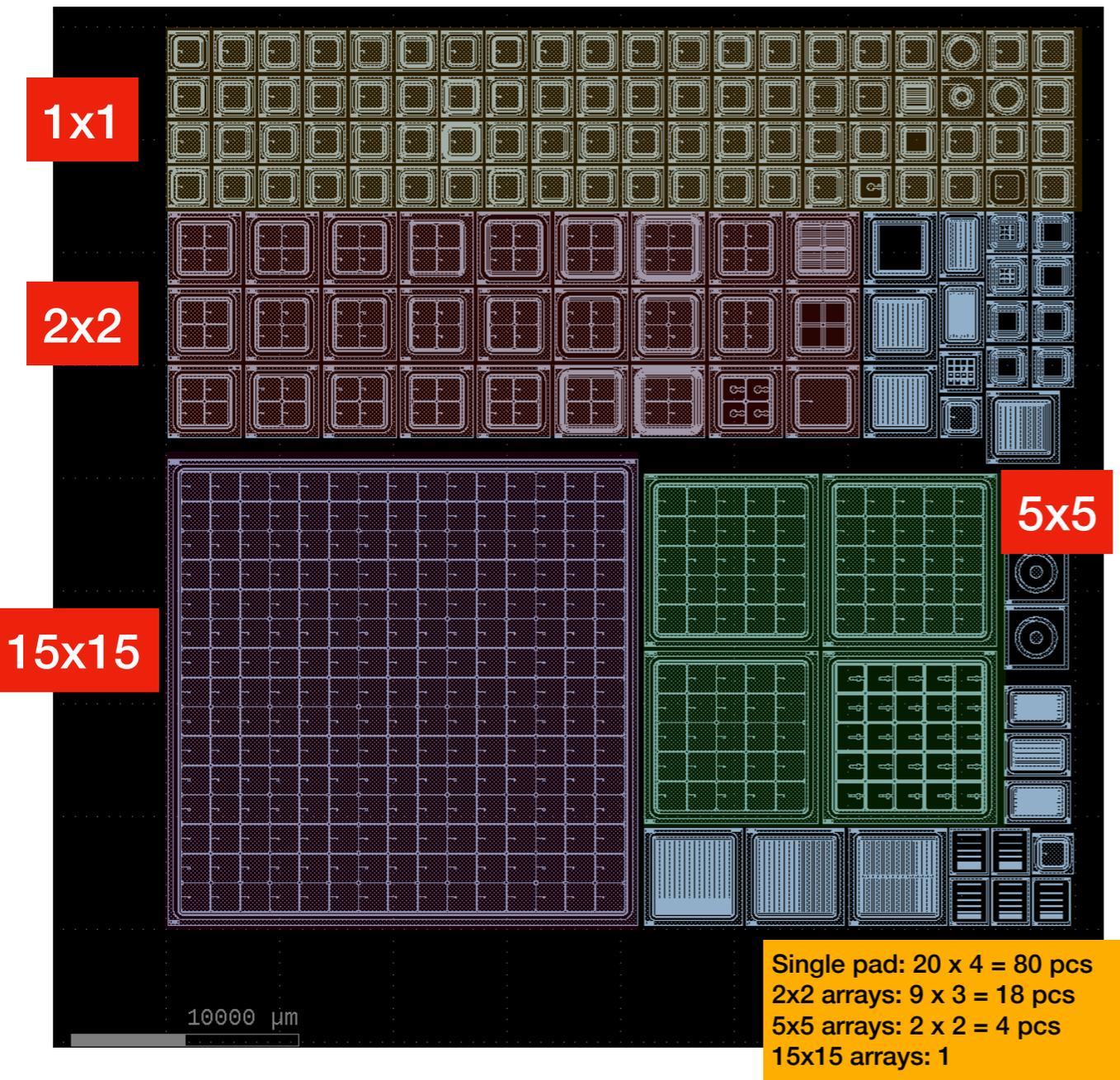
- Deep gain layer provides better recovery capability, with a fixed fraction of acceptor removed

# Carbon diffusion design

- The **Carbon** diffusion profile is designed to have 3-4 times concentration of the **Boron's**
- Make sure the Carbon works and prevent over-dope of the Carbon that might deactivate the Boron by B+C cluster formation.
- Future optimization work will be carefully done at the next batch (including scan of Carbon dose and diffusion depth)
- The irradiation campaigns are being completed at JSI, and the irradiated samples will be studied to optimize the design for the next iteration.



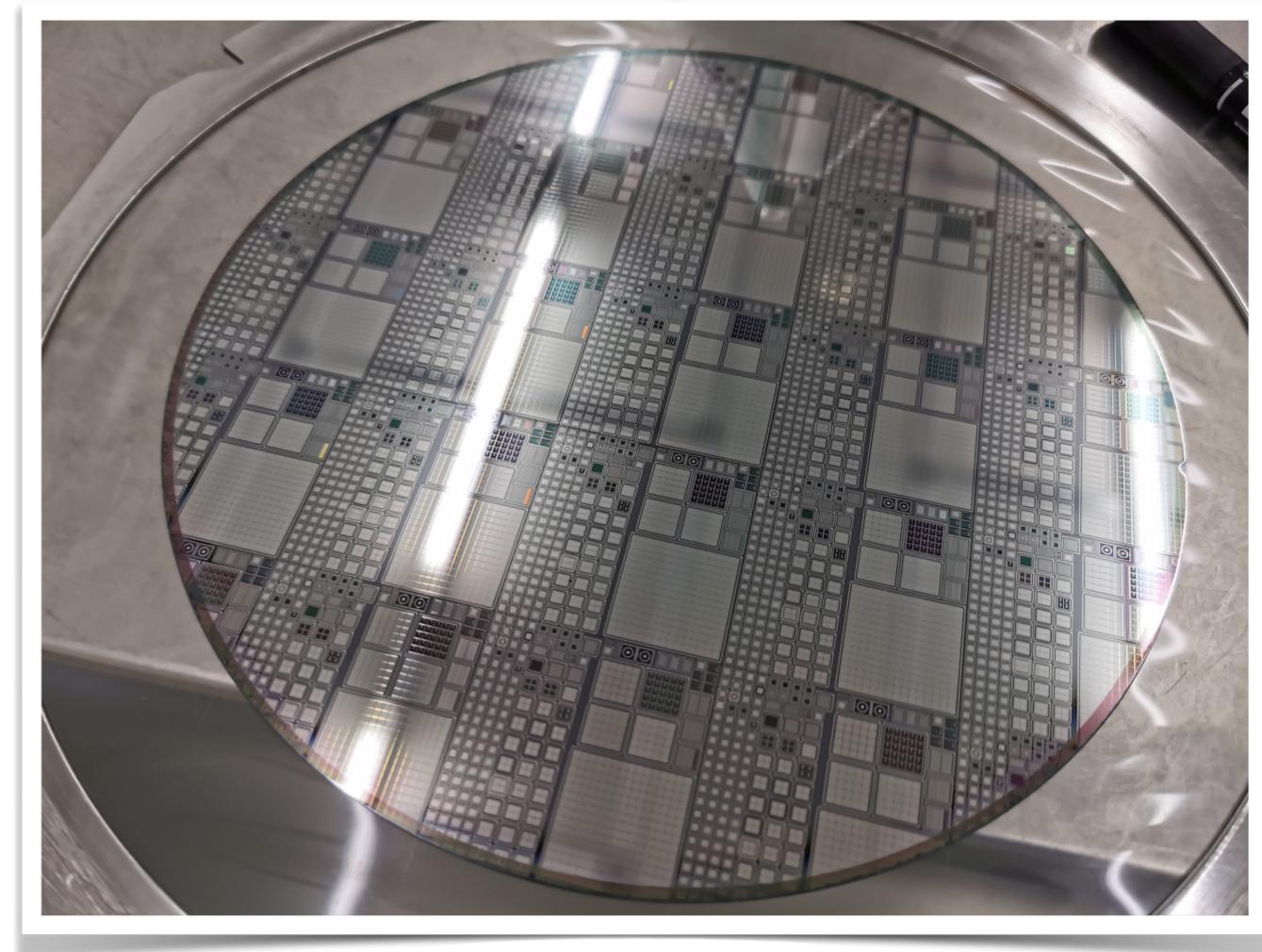
# USTC first batch LGAD Wafers



Joint force: **USTC(Design) + IME,CAS (Fab.)**

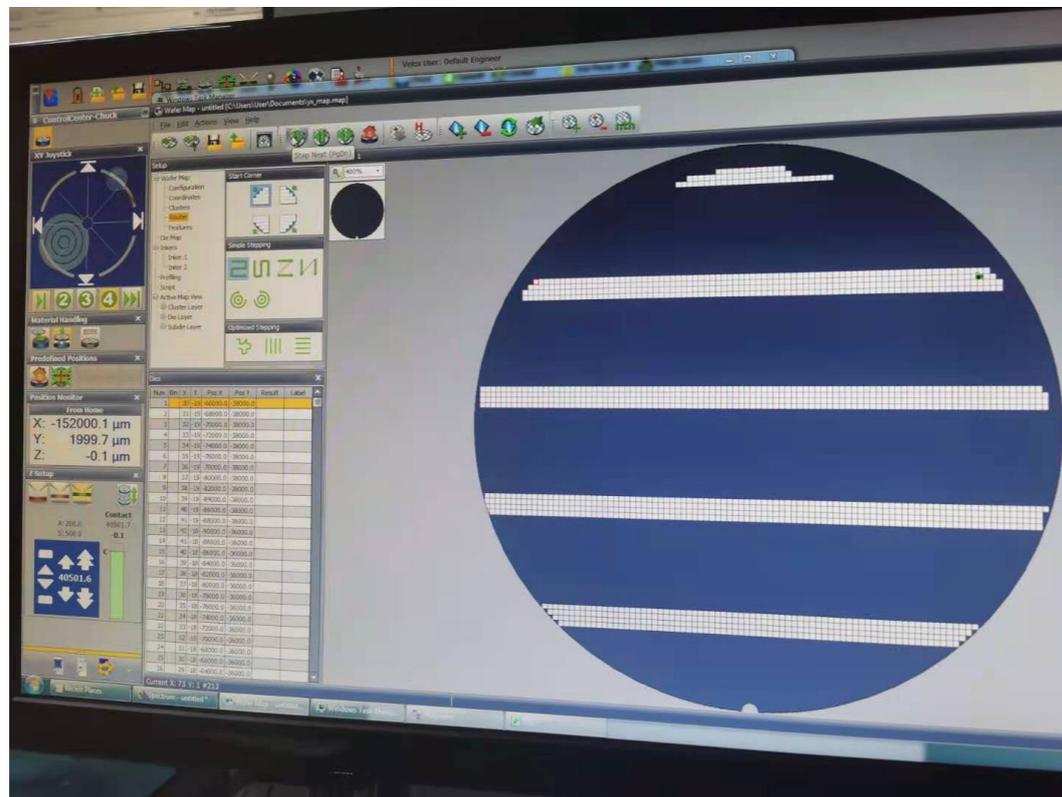
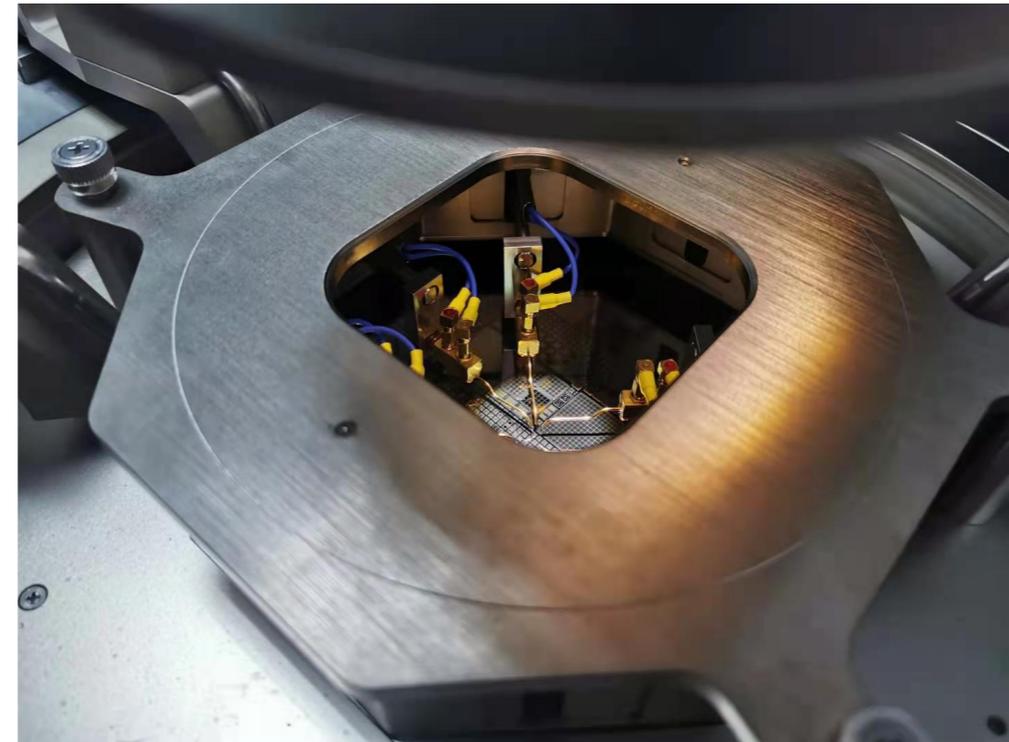
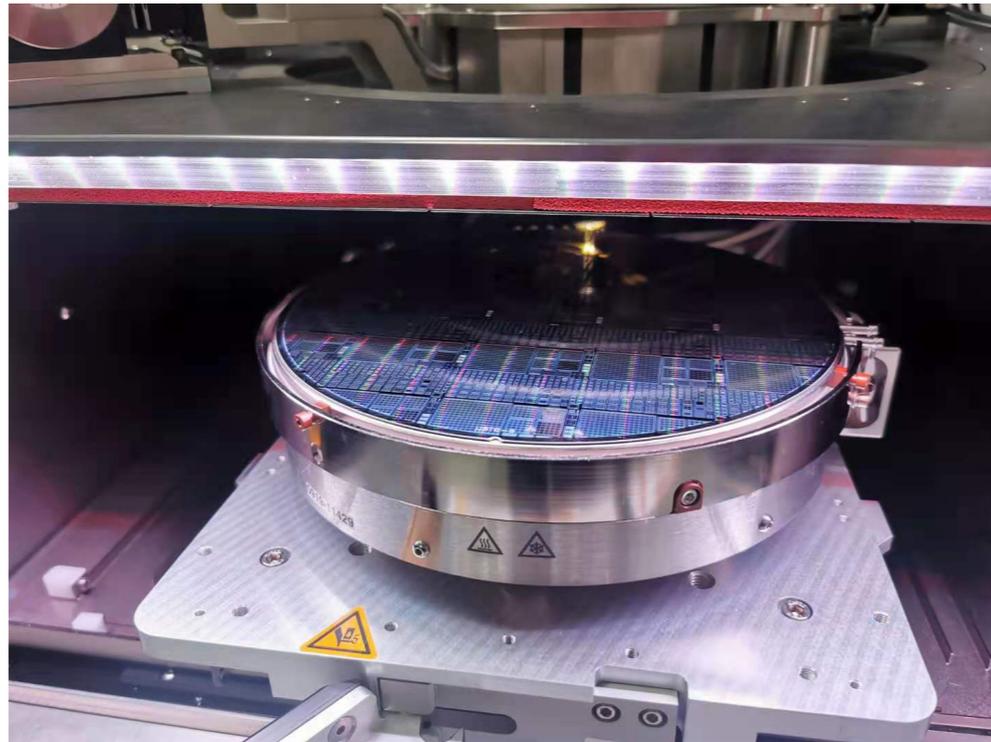
- Deep gain layer
- Carbon diffusion

8 inch wafer, with **50  $\mu\text{m}$**  Epi. layer.  
Stepper size: 40 mm x 40 mm,



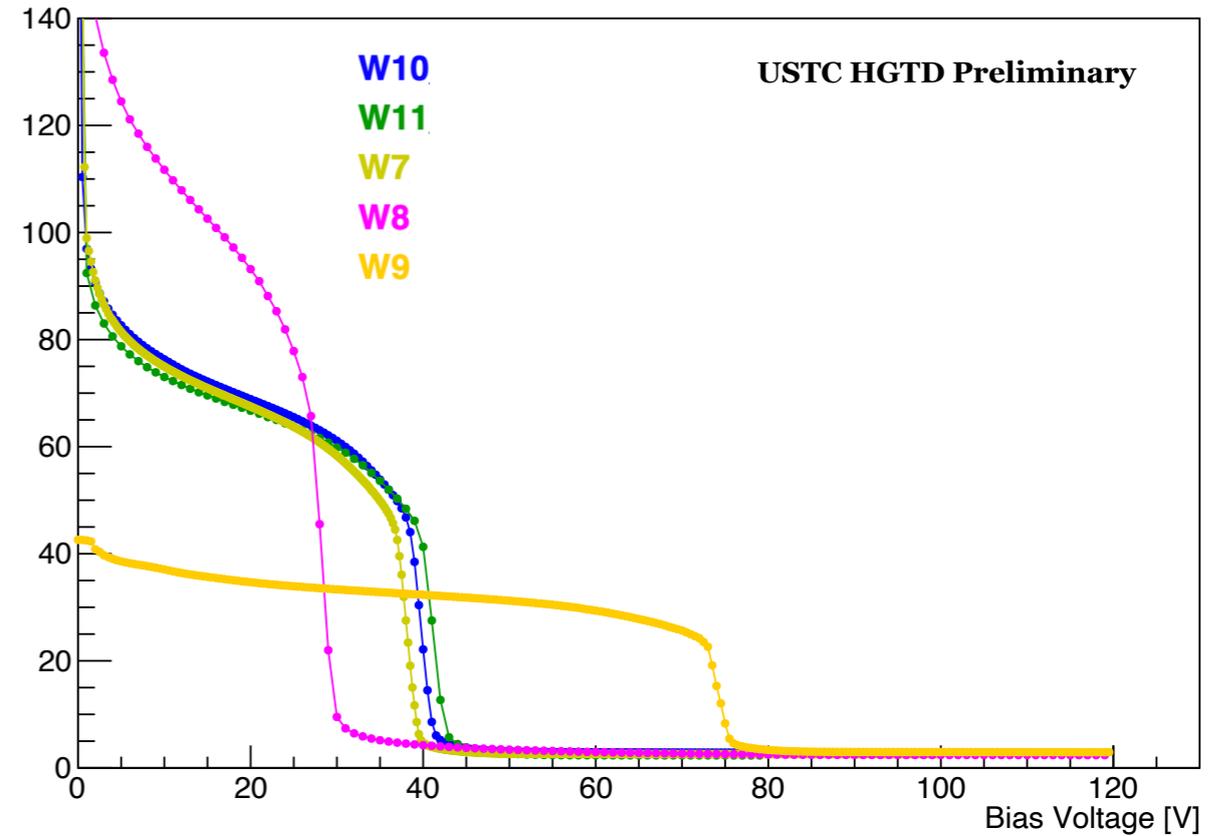
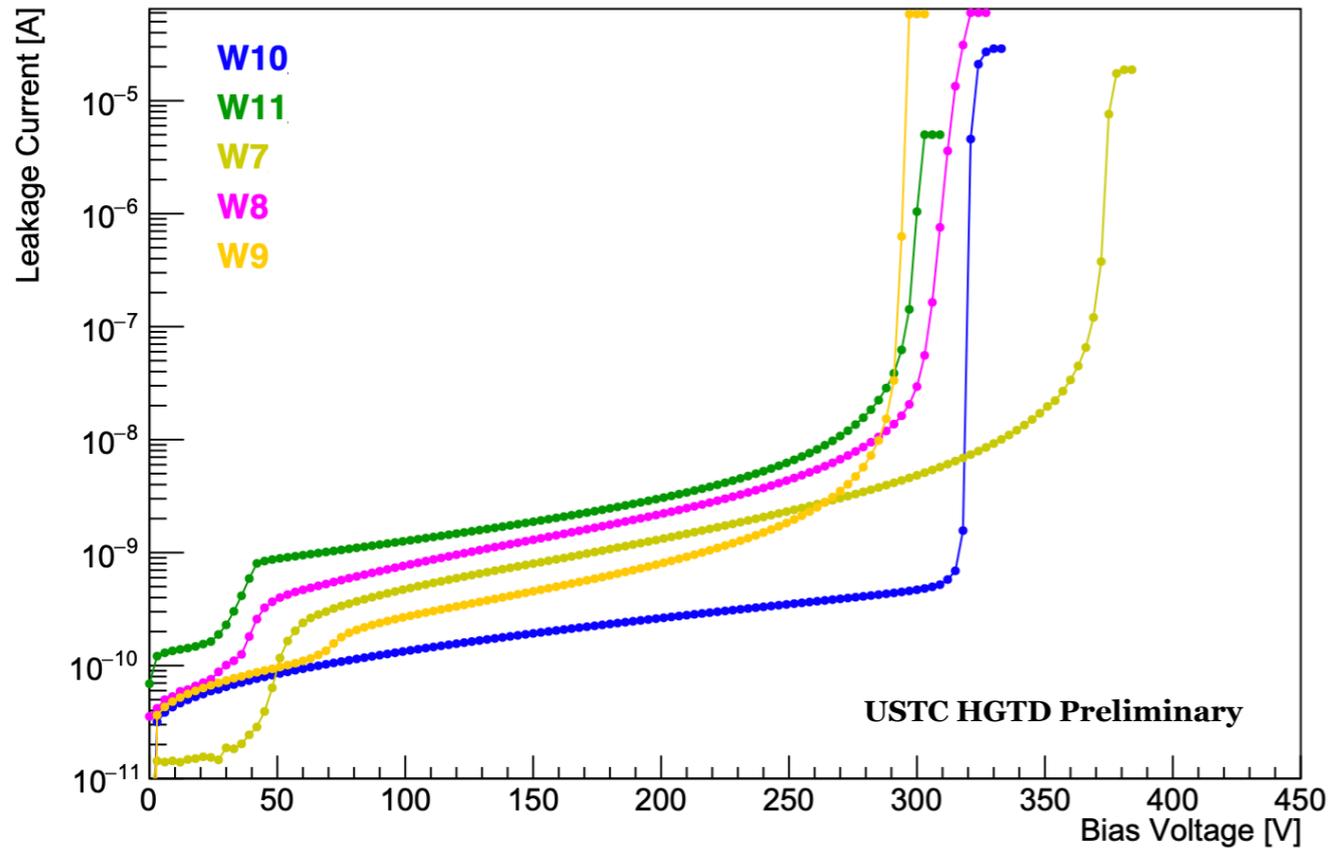
# On-wafer probe with the automagical probe station

*The equipment from the department of micro-electronics, USTC*



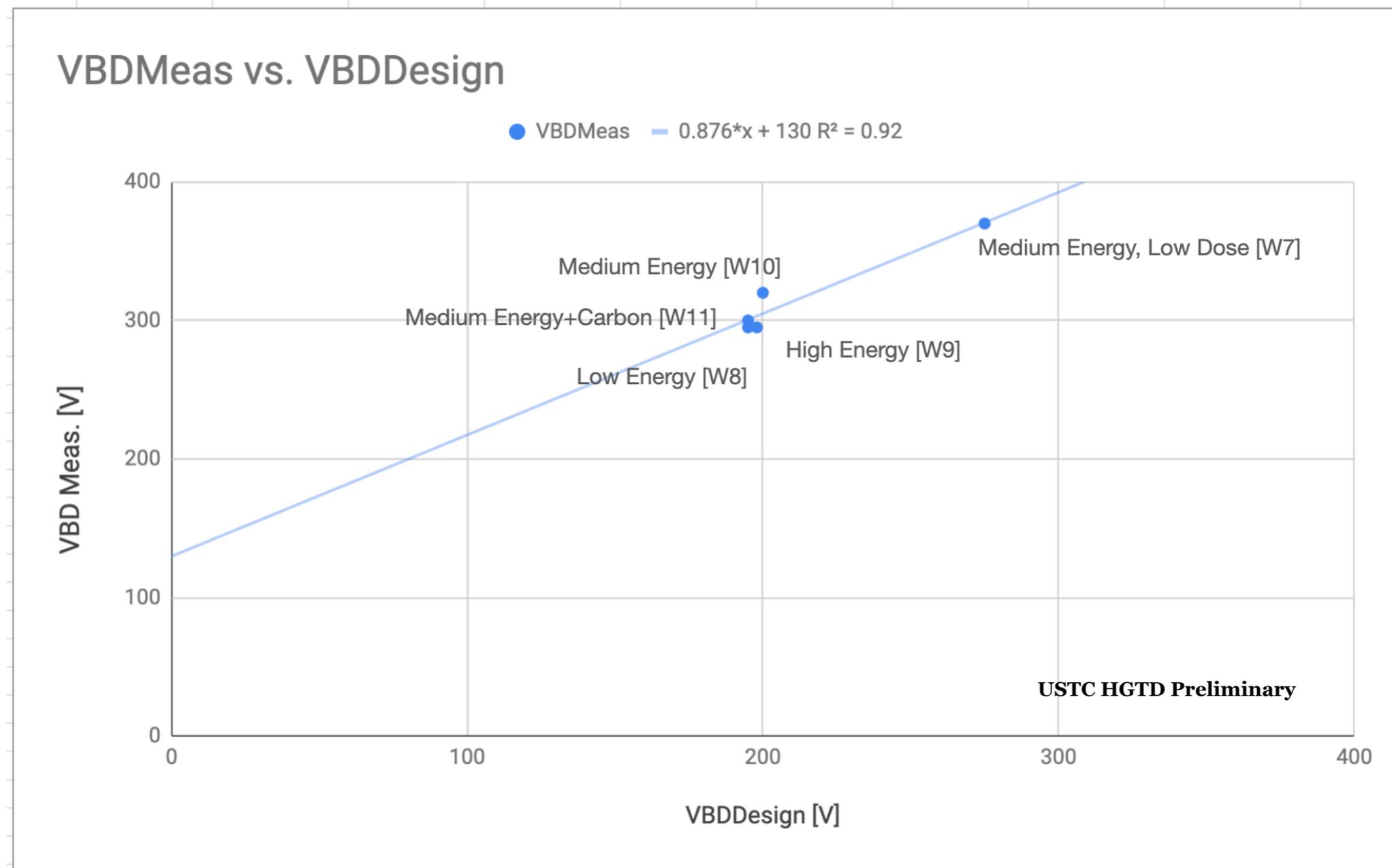
Perform quick on-wafer I-V test for thousands of single sensors' in the range of 0-200V

# USTC First Batch LGADs Summary



Production Batch	Wafer No.	Target VBD [V]	GL.Energy	GL.Dose	Implantation	VBD [V]	VGL [V]	VFD [V]	Status
USTC-1	W1	165	Medium	Medium	B	154	45	65	Pre-production
	W2	165	Medium	Medium	B	150	46	54	
	W3	150	Low	High	B	110	34	>70	
	W4	180	High	Low	B	148	75	100	
	W5	265	Medium	Low	B	264	45	80	
	W6	165	Medium	Medium	B+C	84	48	>65	
USTC-1.1	W7	270	Medium	Low	B	370	38	55	Stable version
	W8	195	Low	High	B	295	29	40	
	W9	200	High	Low	B	295	70	85	
	W10	200	Medium	Medium	B	320	40	50	
	W11	200	Medium	Medium	B+C	300	41	52	

# Comparison of designed and measured VBD

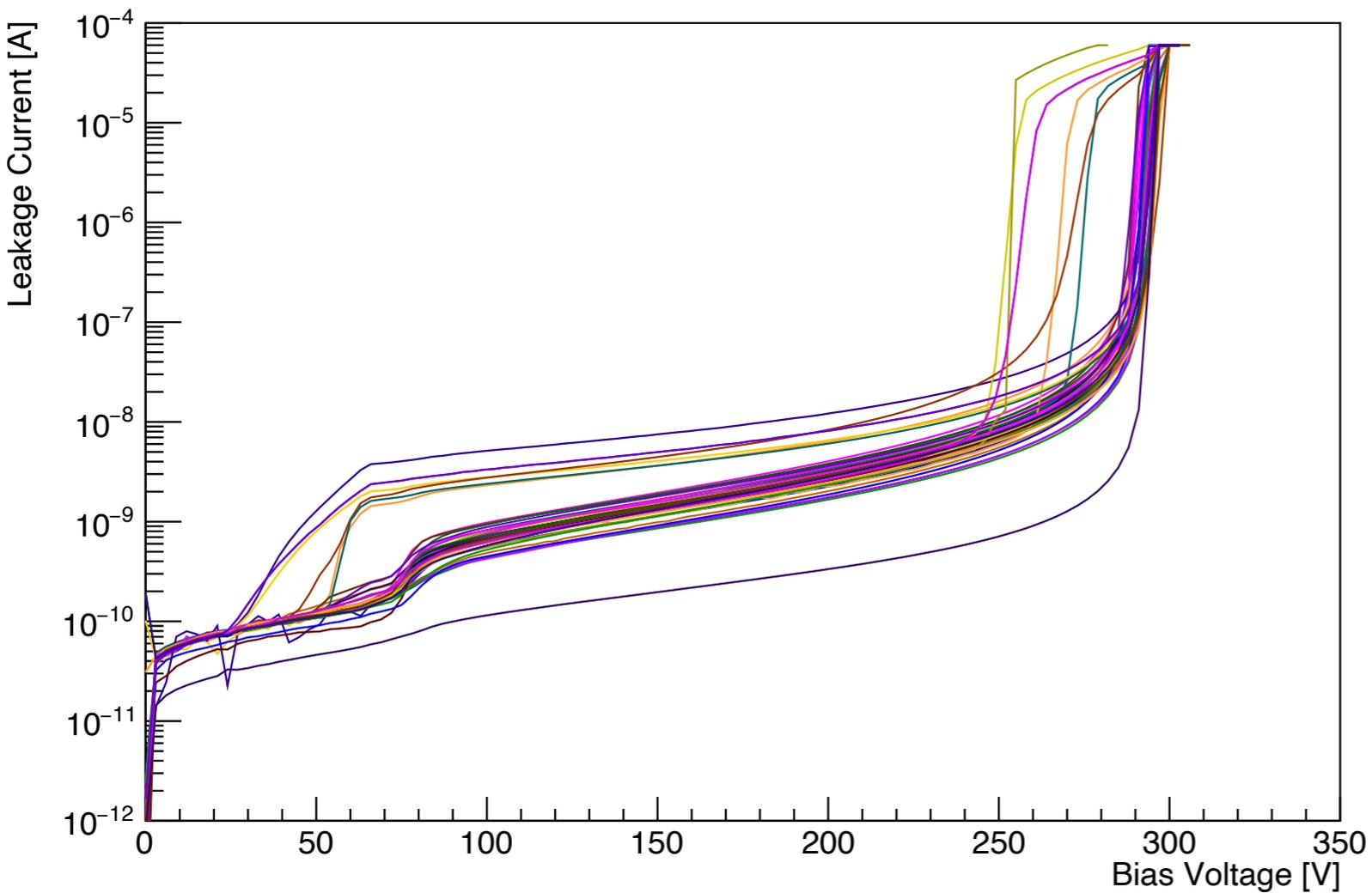


- The detectors with close target VBD show similar measured VBD
- The VBD is  $\sim 100V$  higher than the expectations, further investigation with CV and TCT result is in progress

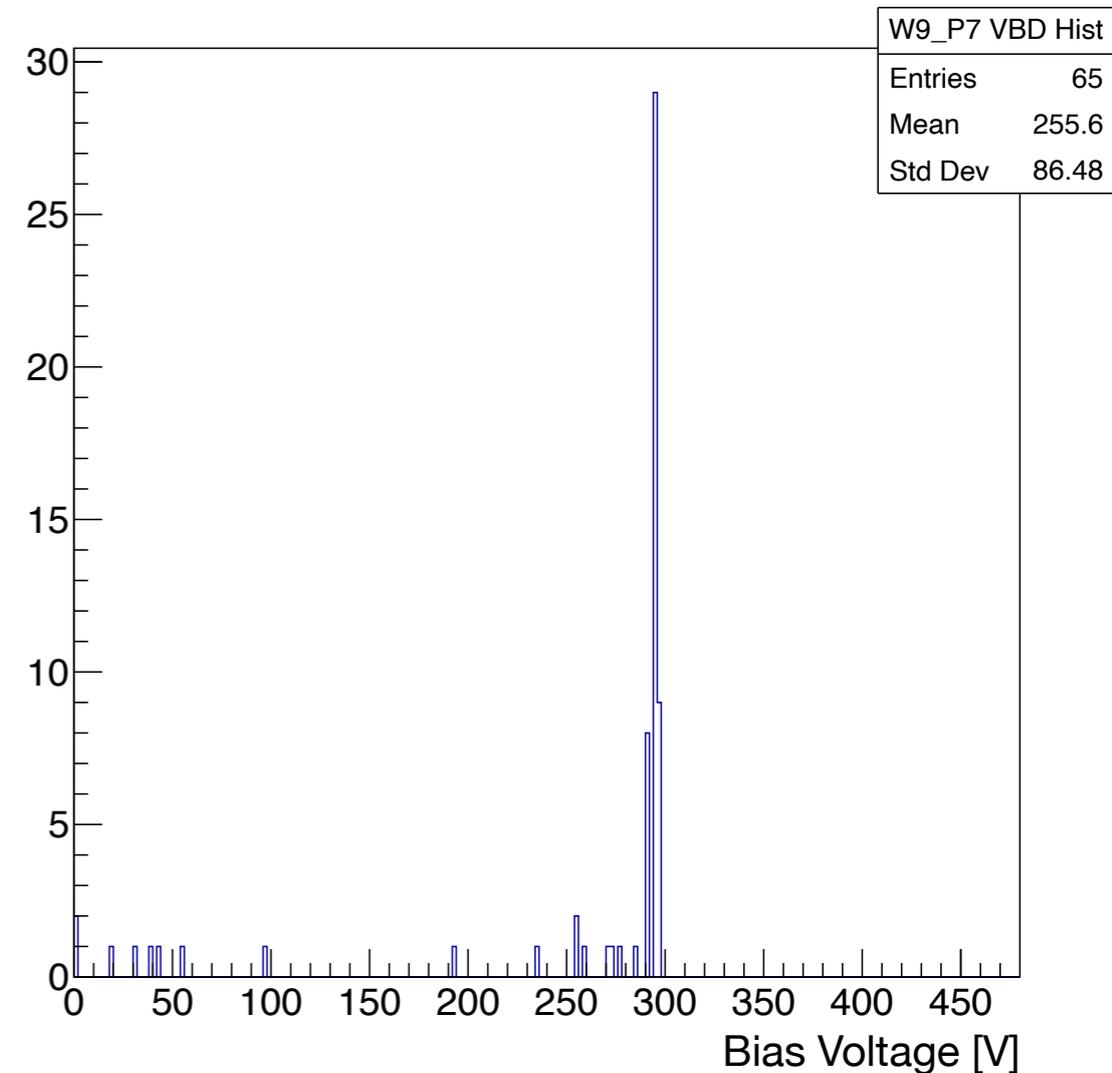
# W9: Ultra-deep gain layer

## IV and VBD Distribution

labprob-Data-IV-SummaryBatch1p1-W9\_P7\_Normal [Log]



W9\_P7 VBD Hist

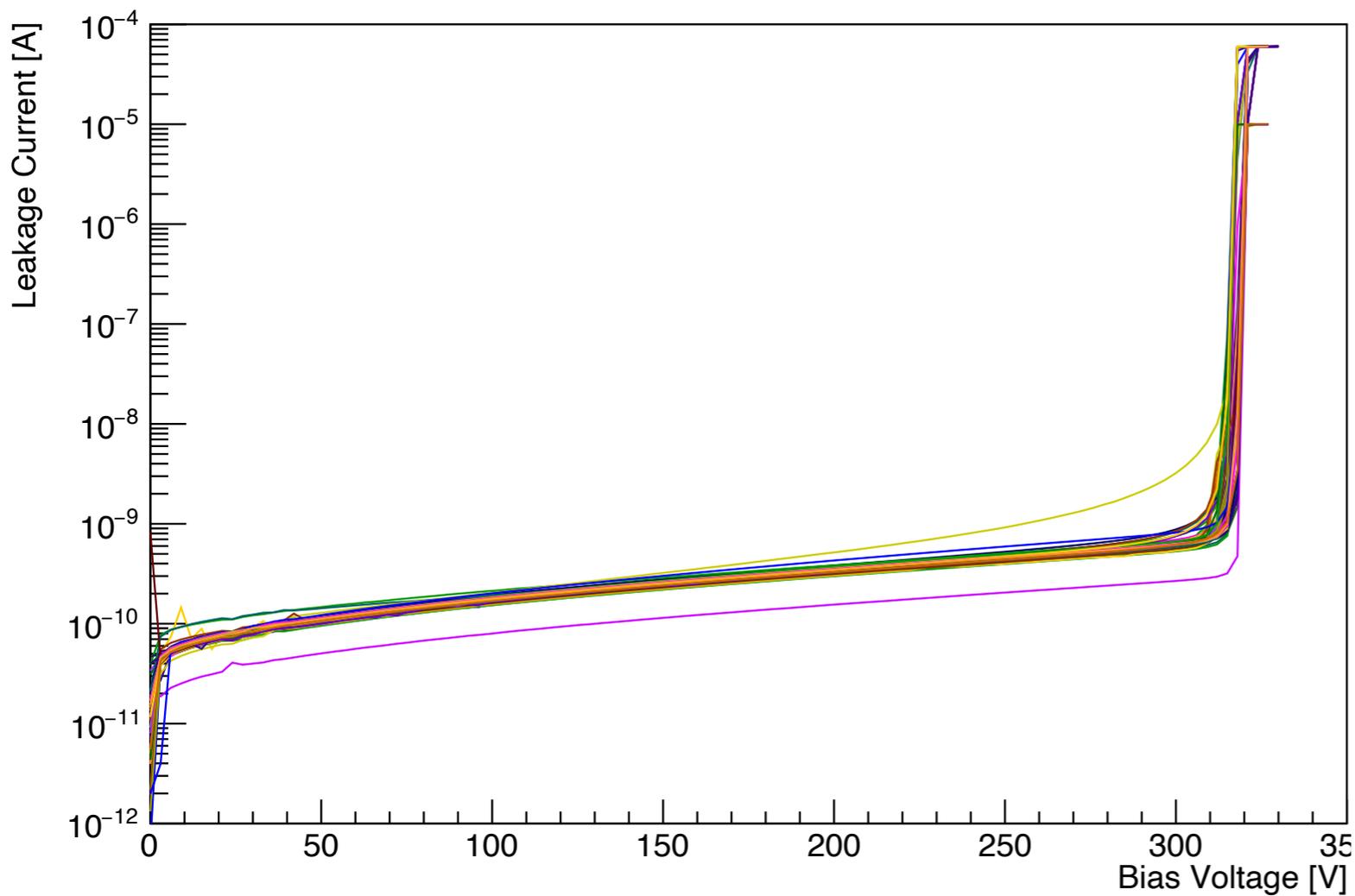


Non-uniform leakage current and VBD for some LGADs,  
further investigation ongoing.

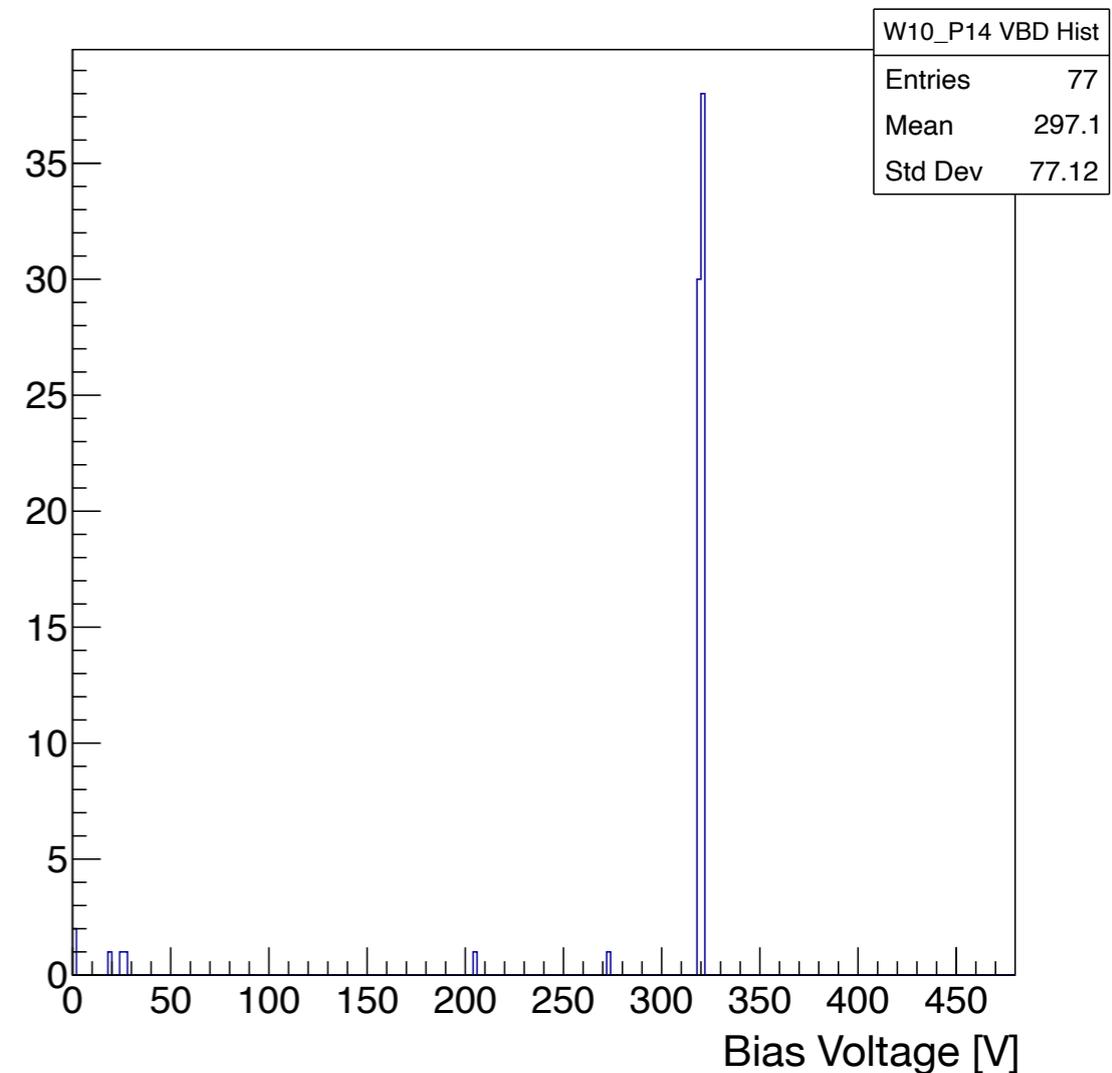
# W10: Baseline gain layer (Mid. Energy&Dose)

## IV and VBD Distribution

labprob-Data-IV-SummaryBatch1p1-W10\_P14\_Normal [Log]



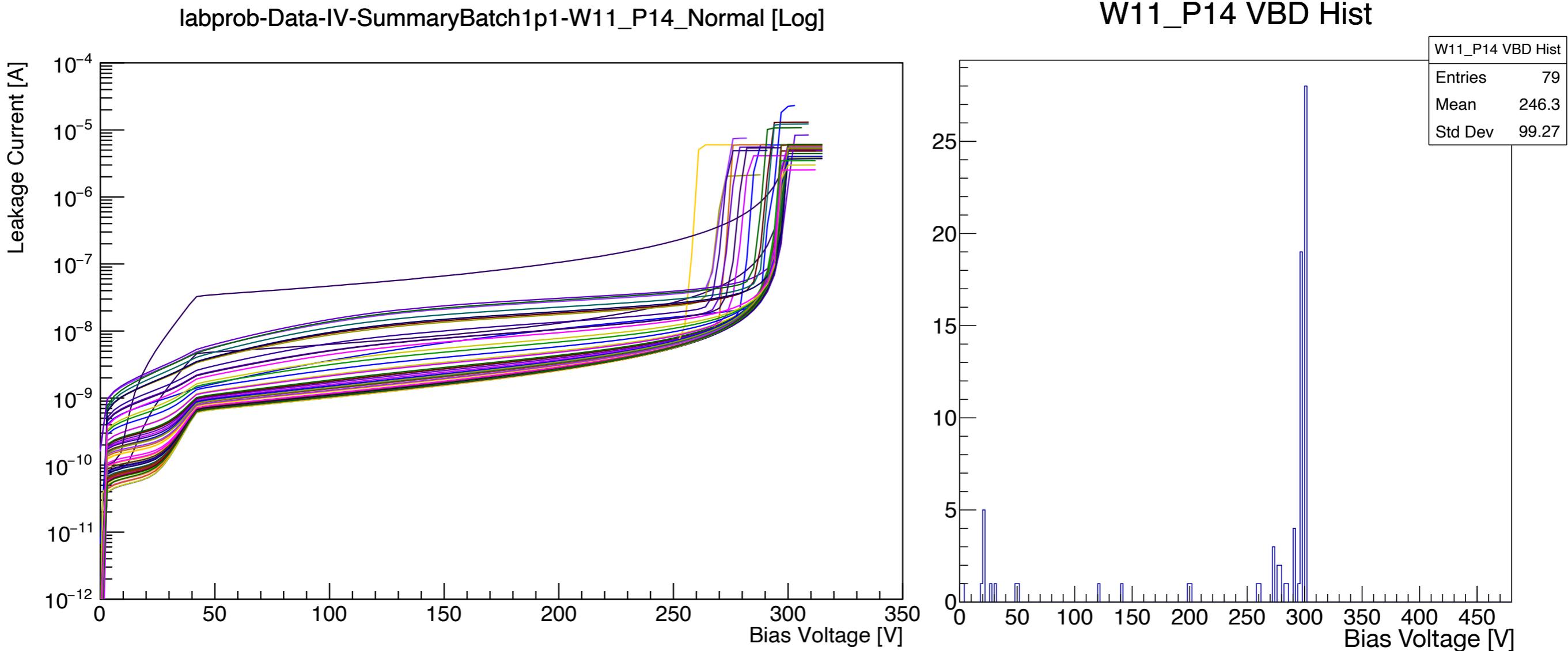
W10\_P14 VBD Hist



Good uniformity on both leakage current and VBD obtained.

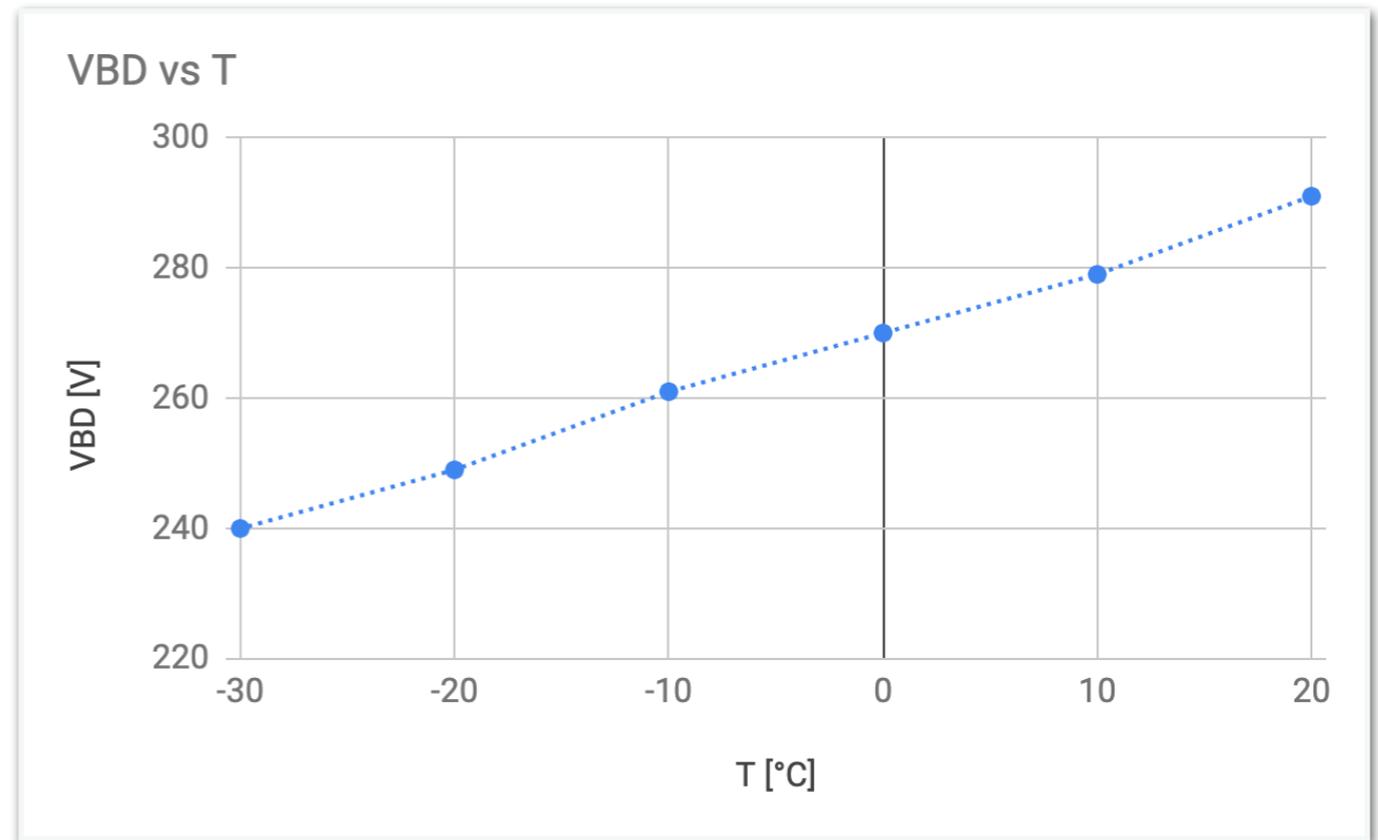
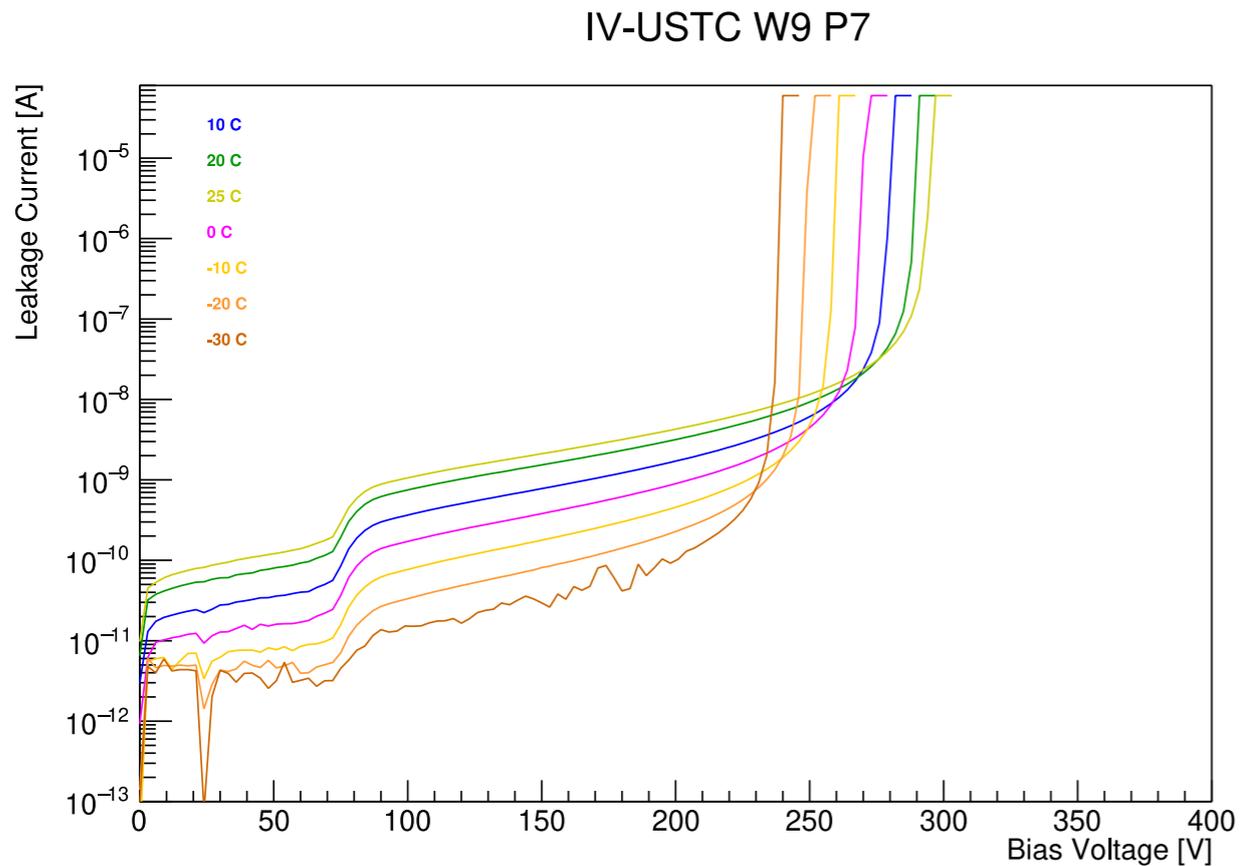
# W11: Carbon diffused gain layer

## IV and VBD Distribution



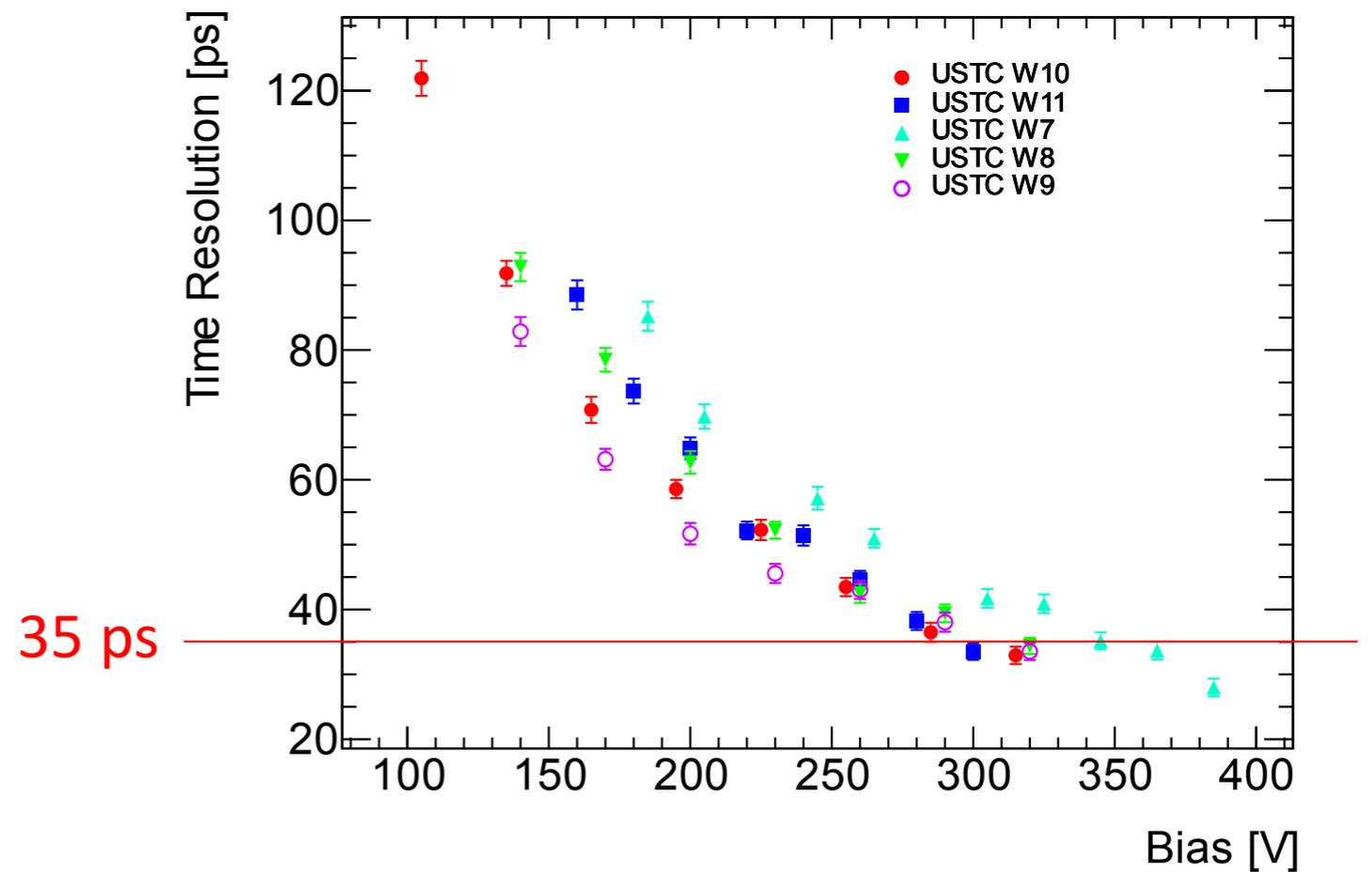
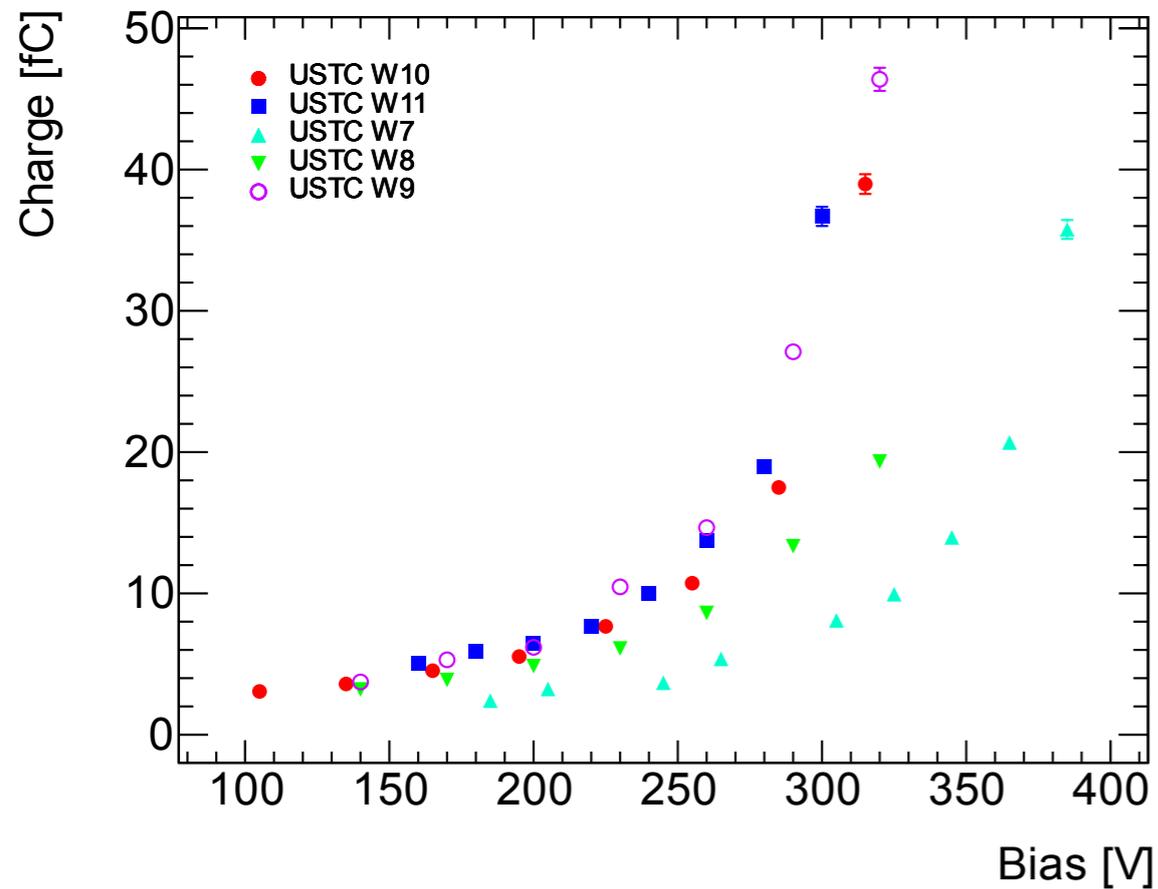
Non-uniform leakage current and VBD for some LGADs, further investigation ongoing.

# Temperature dependency of the I-V curve



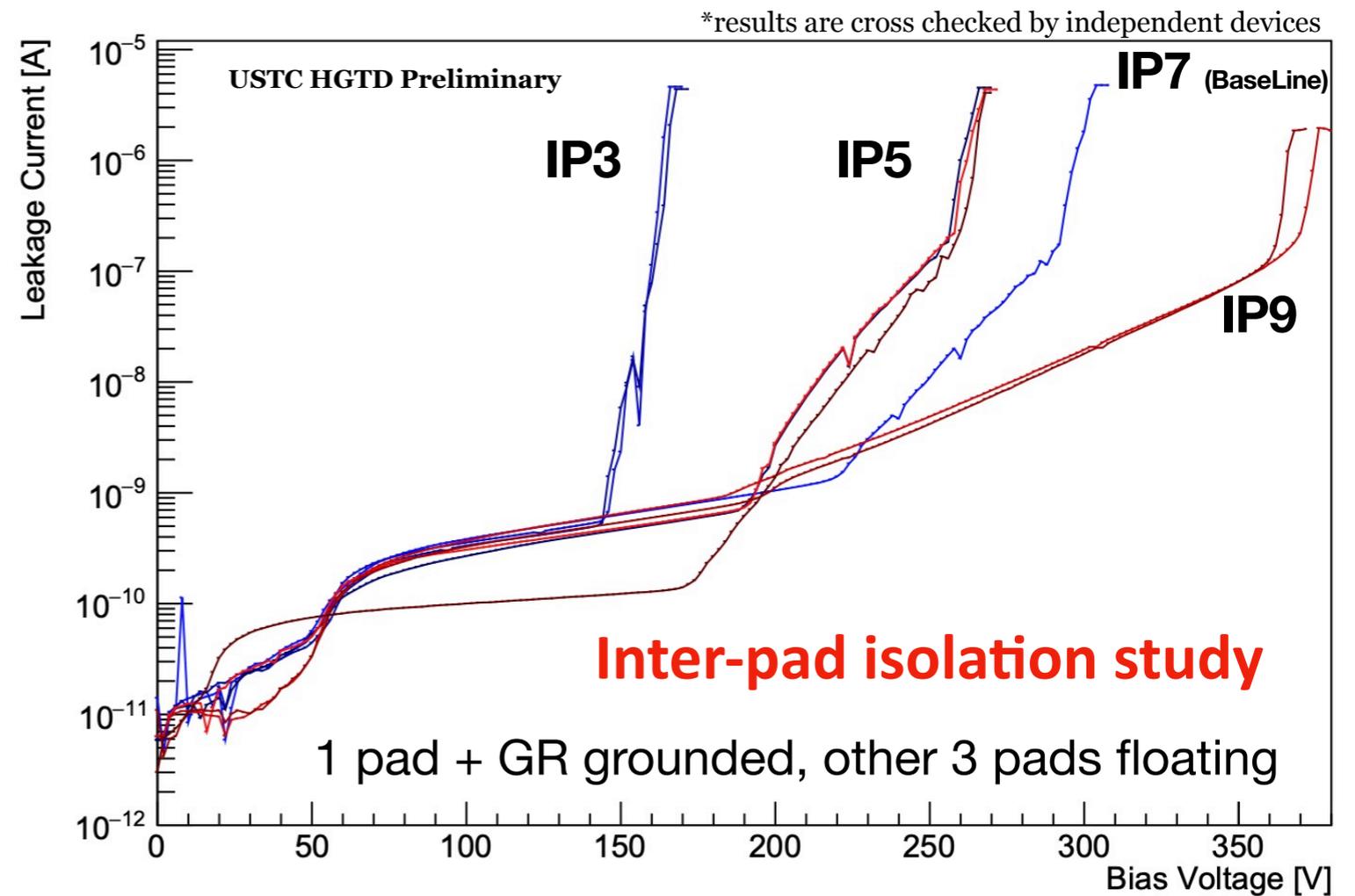
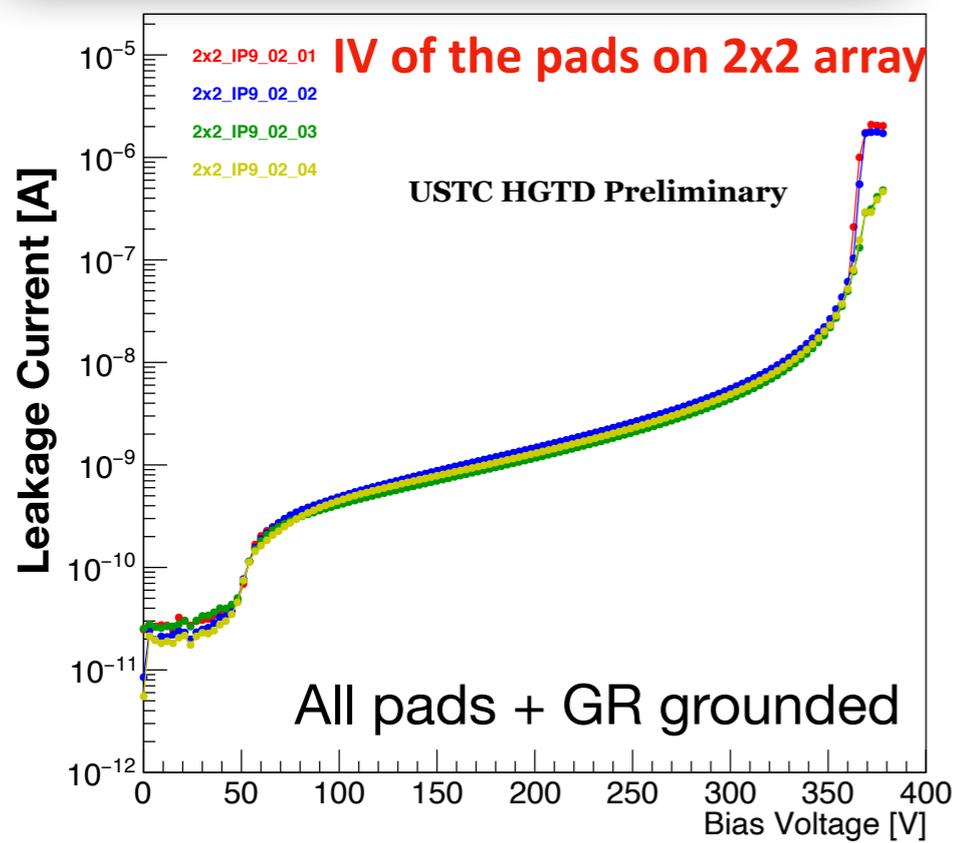
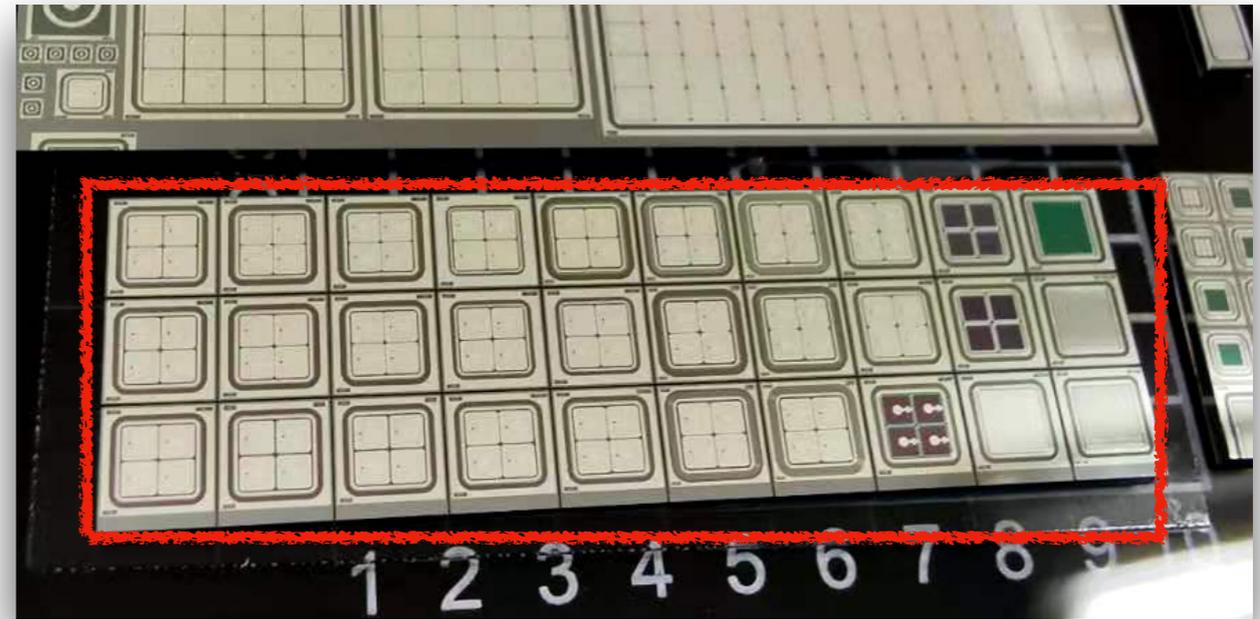
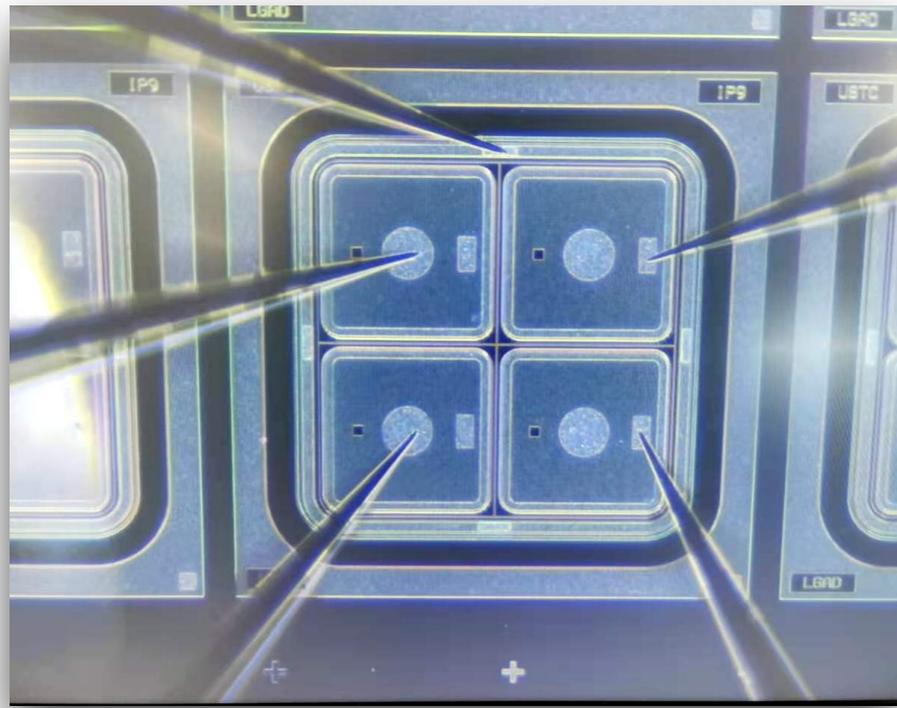
- Sufficient bias after full-depletion ( $\sim 170\text{V}$ ) to saturate the drift velocity at  $-30\text{ }^\circ\text{C}$
- Target VBD will be reduced by  $\sim 70\text{V}$  in next batch.

# Pre-irradiation TCT performance of USTC-1.1

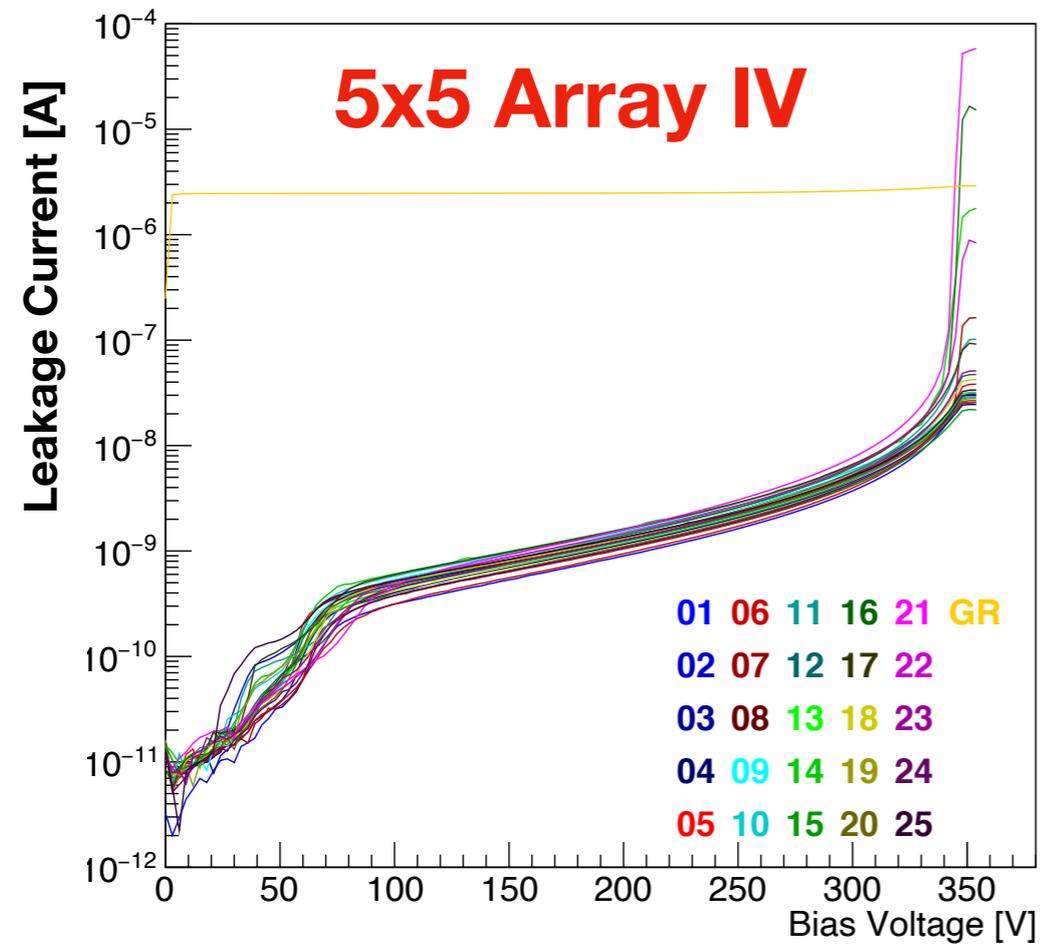


- All the 5 wafers can have time resolution of  $\sim 35$  ps.
- Sensors with deep implantation(W9) and carbon diffusion(W11) can work normally as W10 before irradiation.

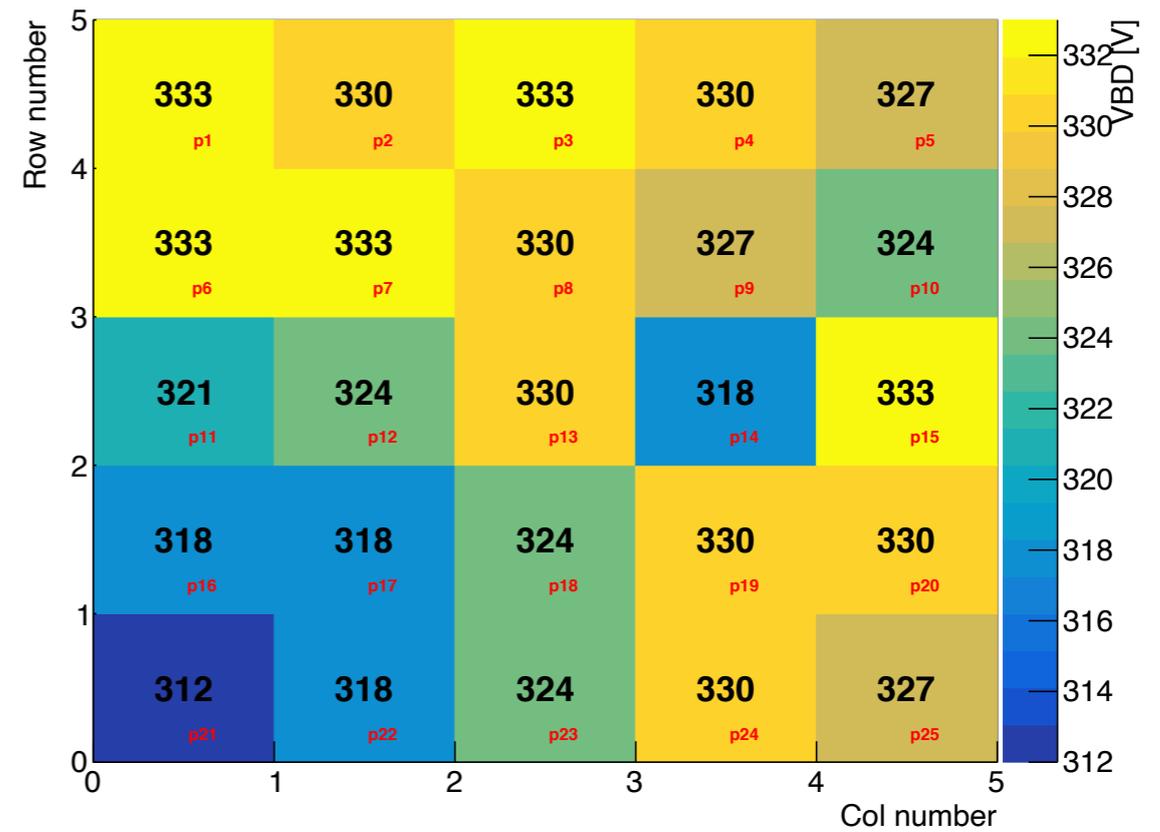
# 2x2 array test of USTC-1.1



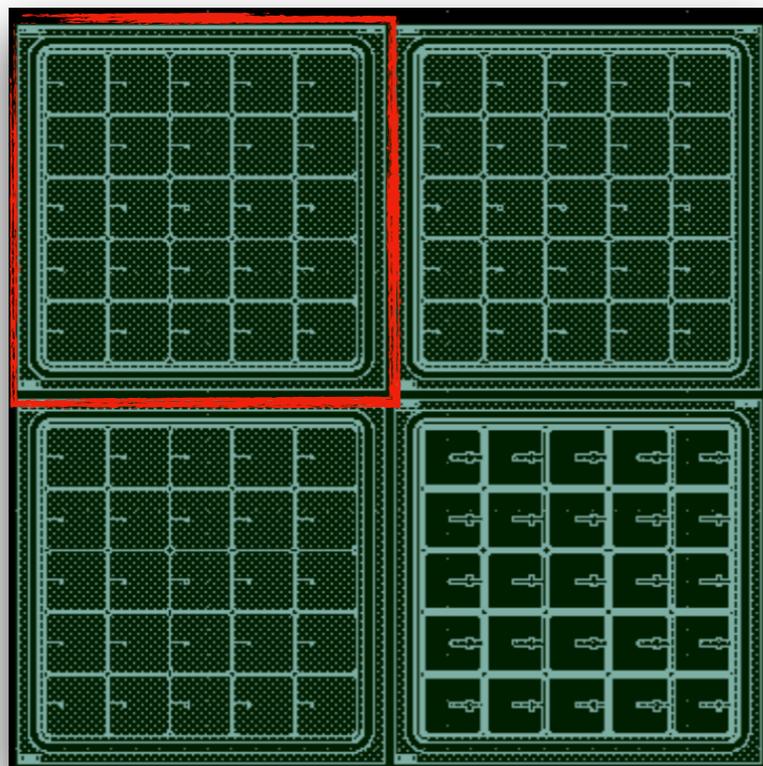
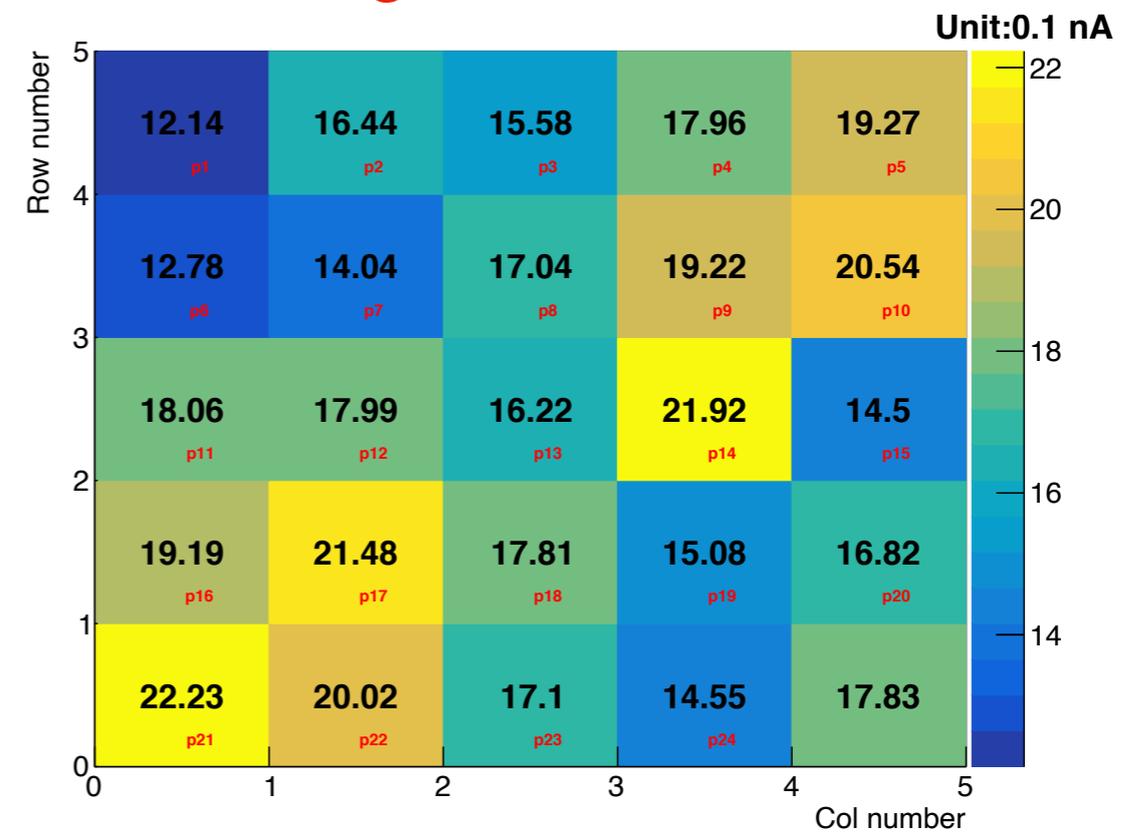
# 5x5 array test of USTC-1.1



## 5x5 VBD distribution



## 5x5 Leakage Current distribution



# Summary and plan for the futures

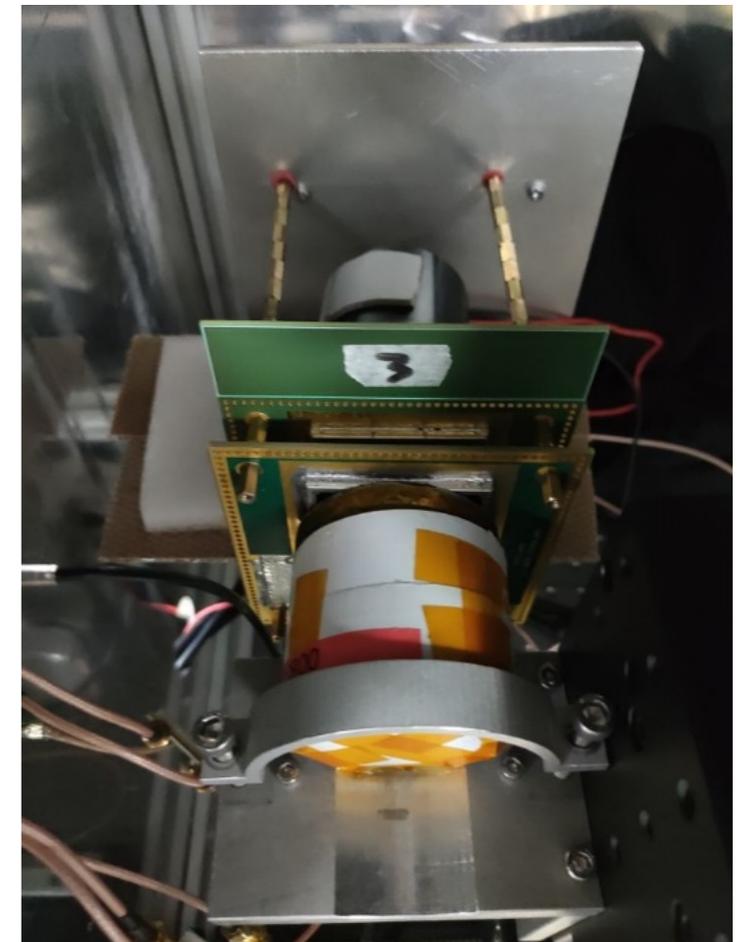
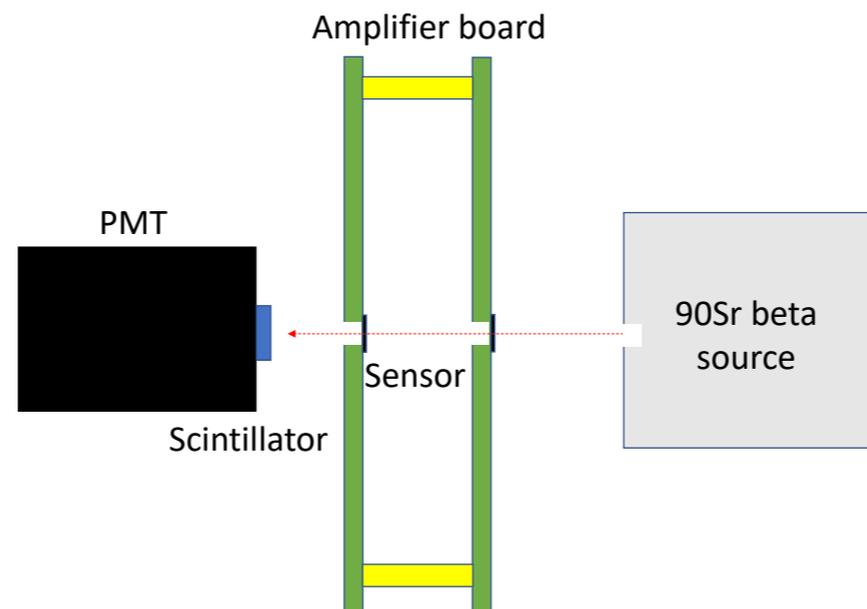
- For USTC-1.1 LGAD, all the 5 wafers have been diced and the sensors are measured to check IV, CV, collected charge and time resolution.
- The single pad LGADs meet the HGTD specifications before irradiation. The 2x2 and 5x5 LGAD arrays I-V curves looks well.
- The sensors with **deep gain layer** and **Carbon diffusion** work well. Expect to have good radiation hardness.
- Plans:
  - Investigation on the non-uniformity observed in leakage current and VBD.
  - Test on the JSI irradiated sensors for post-rad performance validation.
  - Focus on the fabrication process optimization to improve the yield of the large arrays.

**Thanks for your attention!**

# Backup

# Setup of the USTC beta-TCT system

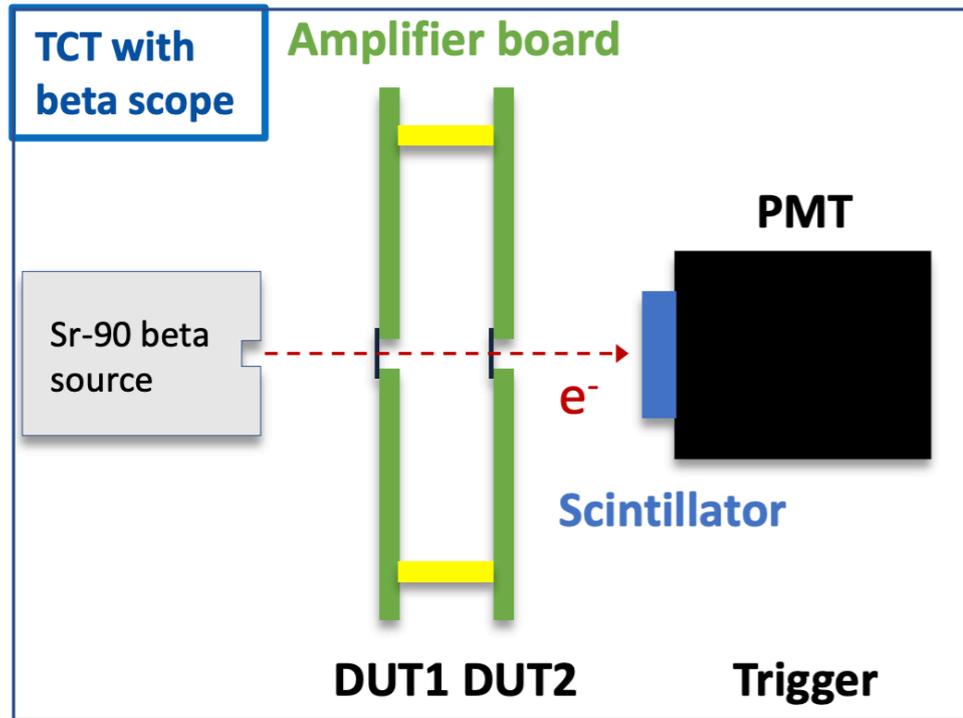
- Room temperature
- Reference
  - UCSC pre-amplifier & HPK Type 1.1 single, un-irradiated
  - With the 2<sup>nd</sup> stage amplifier
  - Bias: -210V
- DUT
  - UCSC pre-amplifier & USTC-1.1 single, un-irradiated
  - With the 2<sup>nd</sup> stage amplifier
- Trigger (Coincidence with reference)
  - R5924 PMT & EJ 232 Scintillator
  - With the attenuator
  - HV: +2000V
  - Threshold: 350 mV
- Oscilloscope
  - Sampling rate: 20 Gs/s
  - Bandwidth: 1 GHz



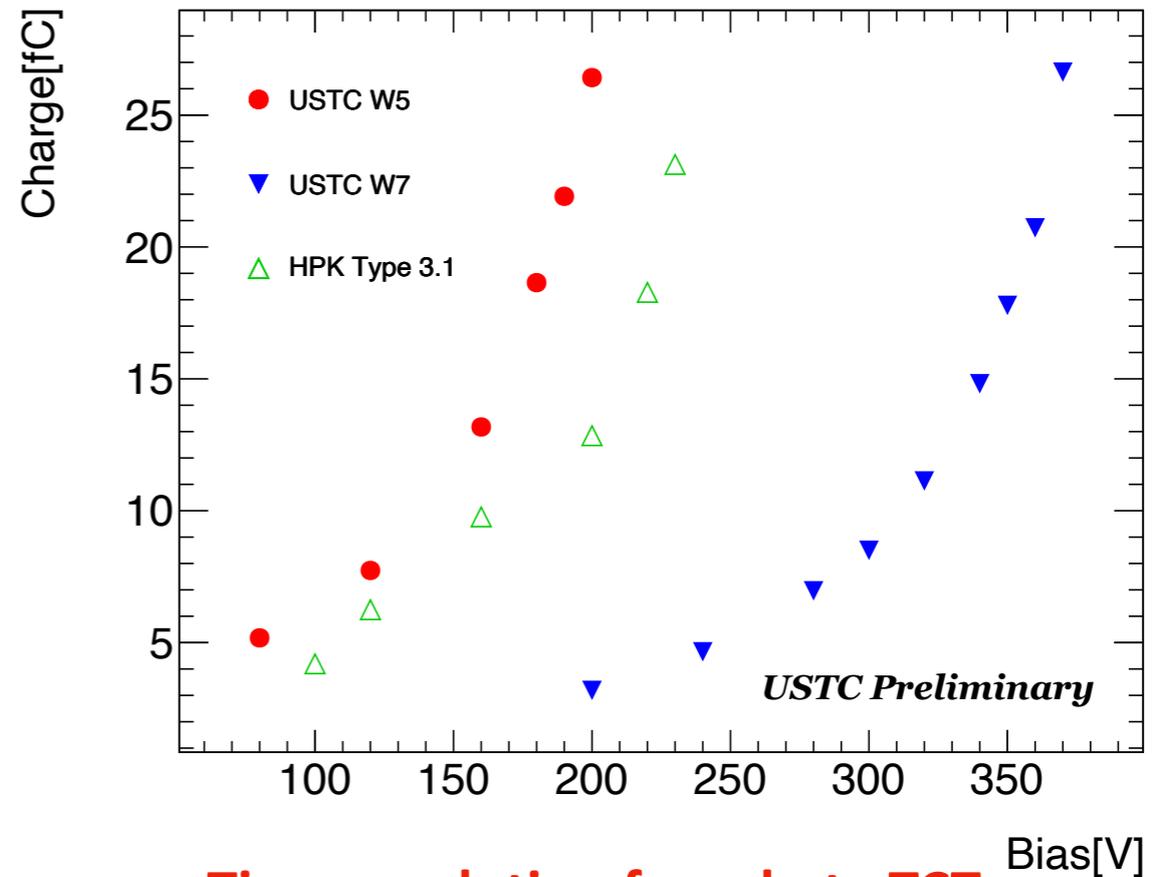
# Performance from TCT

by Chihao Li

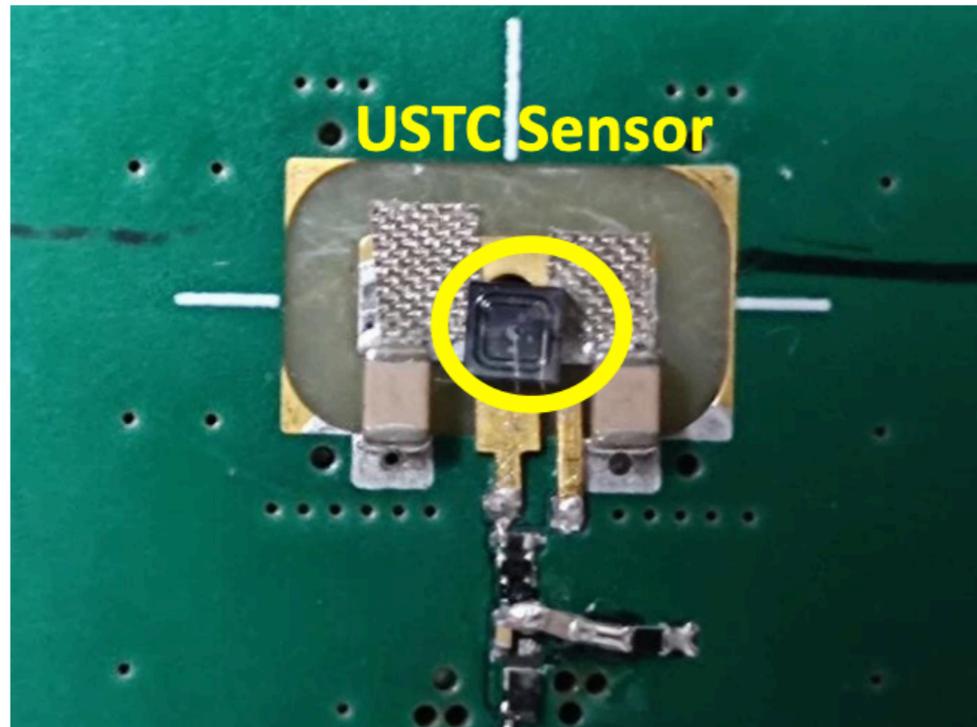
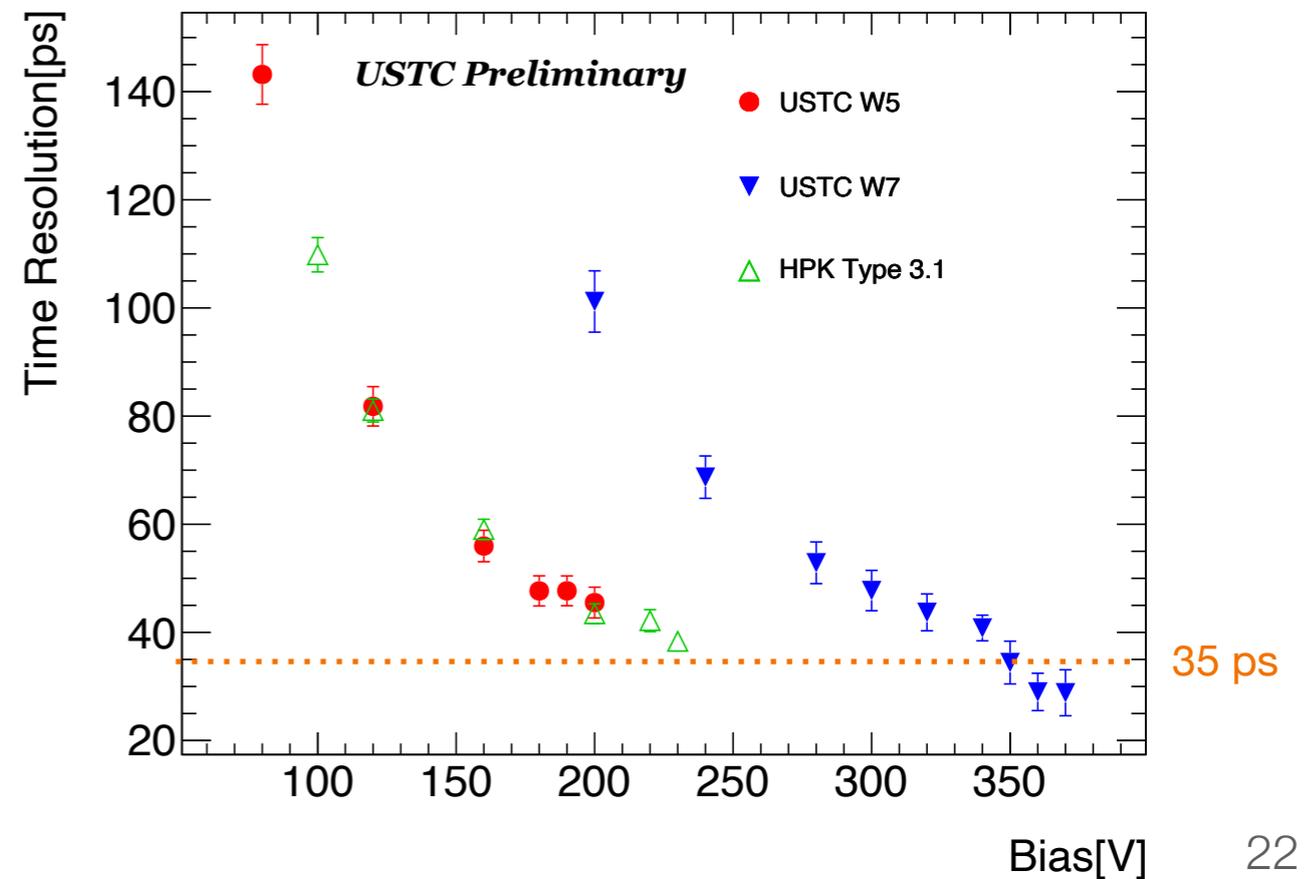
## TCT System at USTC



## Collected Charge from beta TCT



## Time resolution from beta TCT



Pre-amplifier board from UCSC